

# Elettra Sincrotrone Trieste



# Powder Diffraction with Synchrotron Radiation





- · What is powder diffraction
- How do we measure powder diffraction and what do we have to be aware of
- Instrumentation at synchrotron beamlines for powder diffraction
- Why perform powder diffraction at synchrotrons
- Applications of SR-XRPD

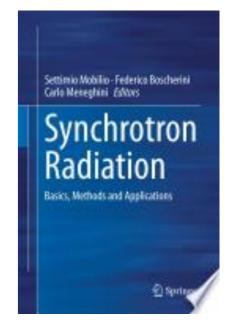


#### Synchrotron Radiation: Basics, Methods and Applications

Chapter 10:

Powder Diffraction and synchrotron radiation

- Chapter 18:
  - Diffraction from nanocrystalline materials
- Chapter 24:
  - Synchrotron radiation and earth sciences
- Chapter 25:
  - . Synchrotron radiation and environmental sciences
- Chapter 26:
  - Synchrotron radiation in art, archeology and cultural heritage
- Chapter 29:
  - Studies of matter at extreme conditions





Oxford Dictionary:

#### powder

Pronunciation: /'paude/ fine, dry particles produced by the grinding, crushing, or disintegration of a solid

#### solid

Pronunciation: /'splid/

- **1** a substance or object that is solid rather than liquid or fluid.
- 2 Geometry a body or geometric figure having three dimensions.



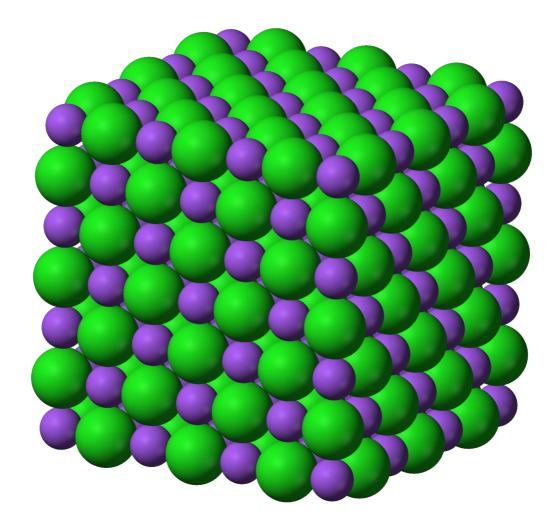






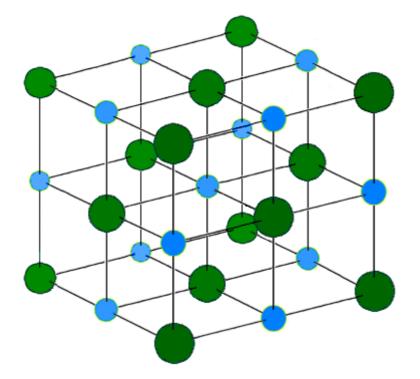






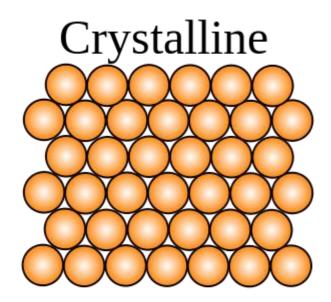


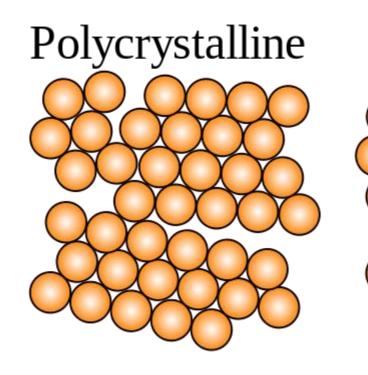
## Unit cell

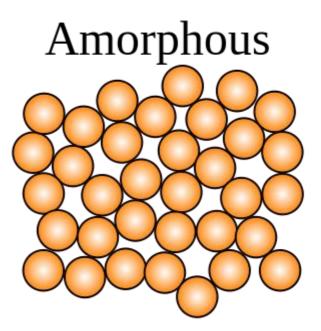






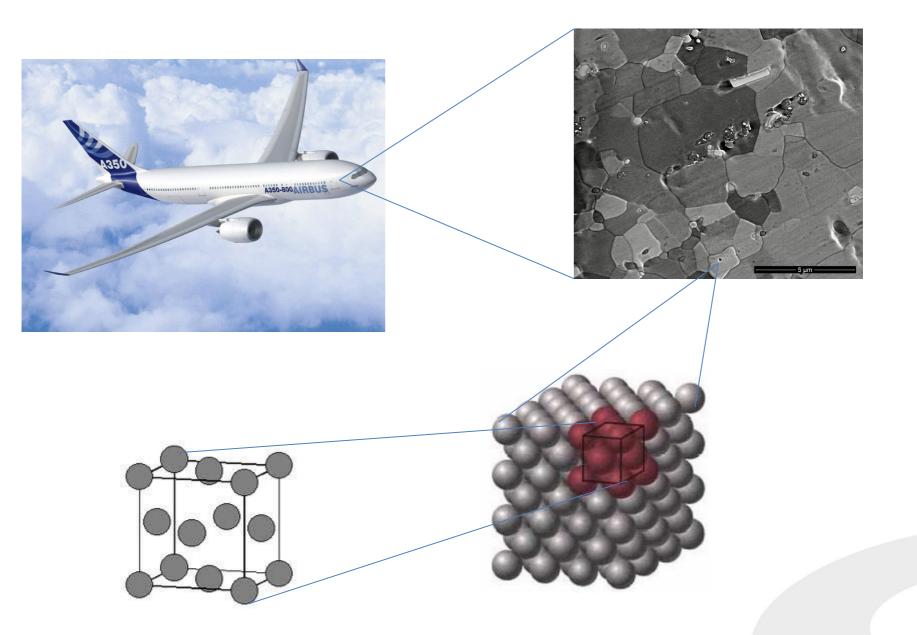












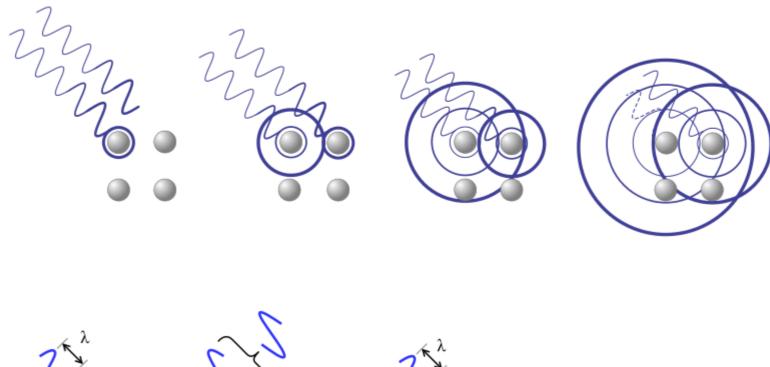


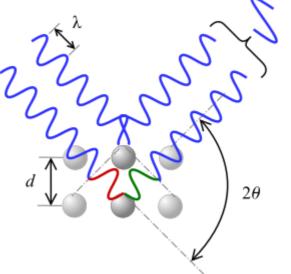


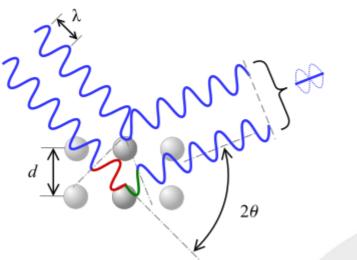




X-ray Diffraction

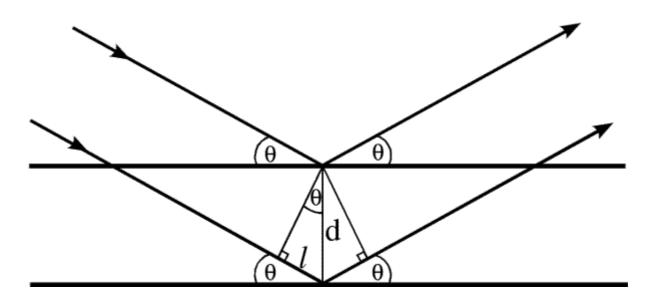












The two X-ray beams travel at different distances. This difference is related to the distance between parallel planes

### $2l = d \sin \Theta$ $n\lambda = 2d \sin \Theta$





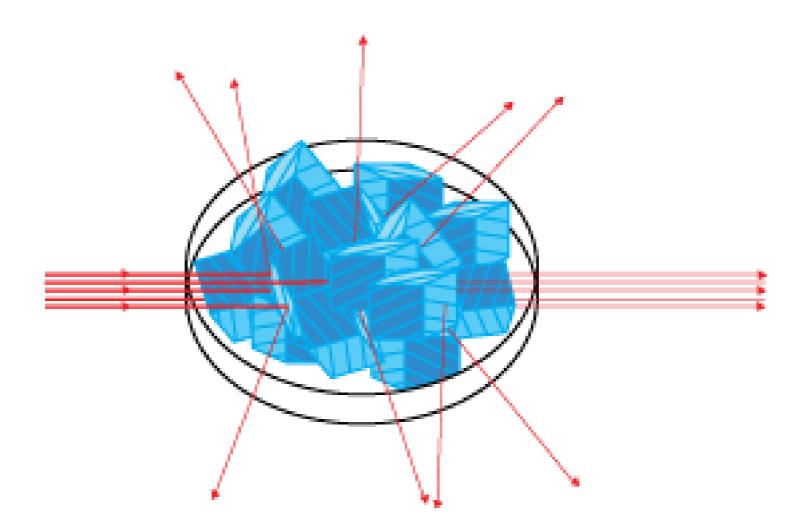
This condition is met when the distance equals an integer multiple of the wavelength, called order of diffraction, n. The final equation is the BRAGG'S LAW

 $n\lambda = 2d \sin \Theta$ 

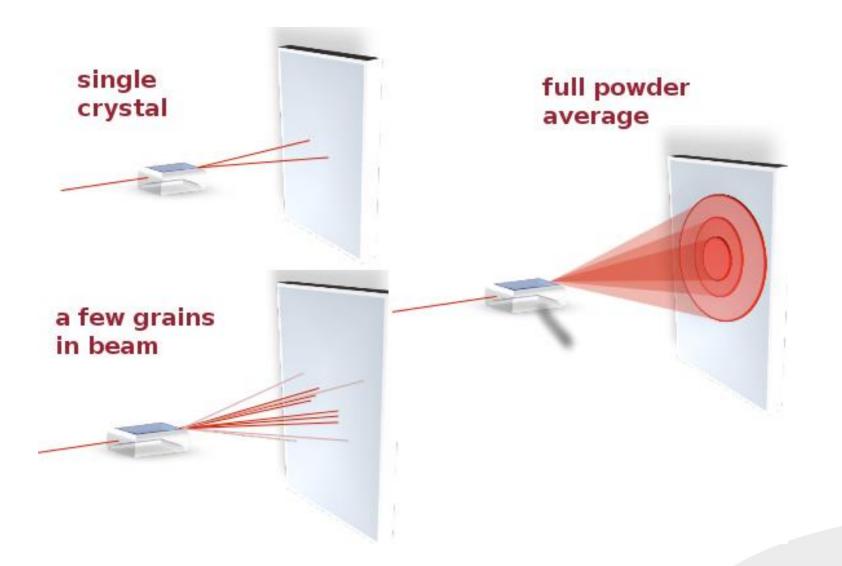
Data are collected by using X-rays of a known wavelength. The sample is rotated so that the angle of diffraction changes

When the angle is correct for diffraction a signal is recorded

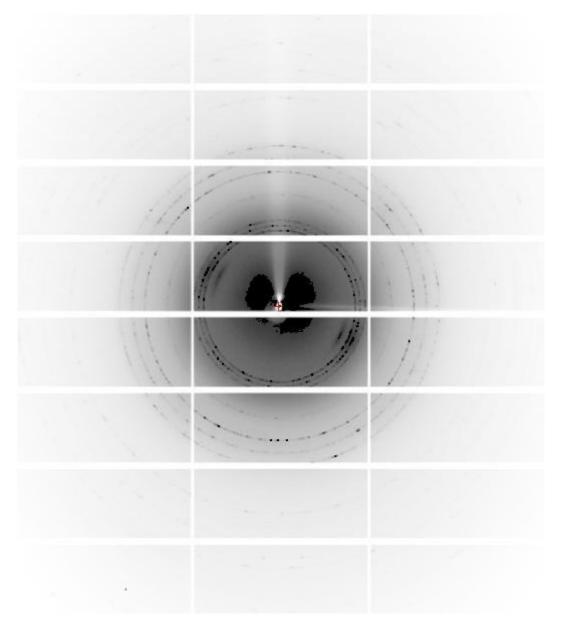


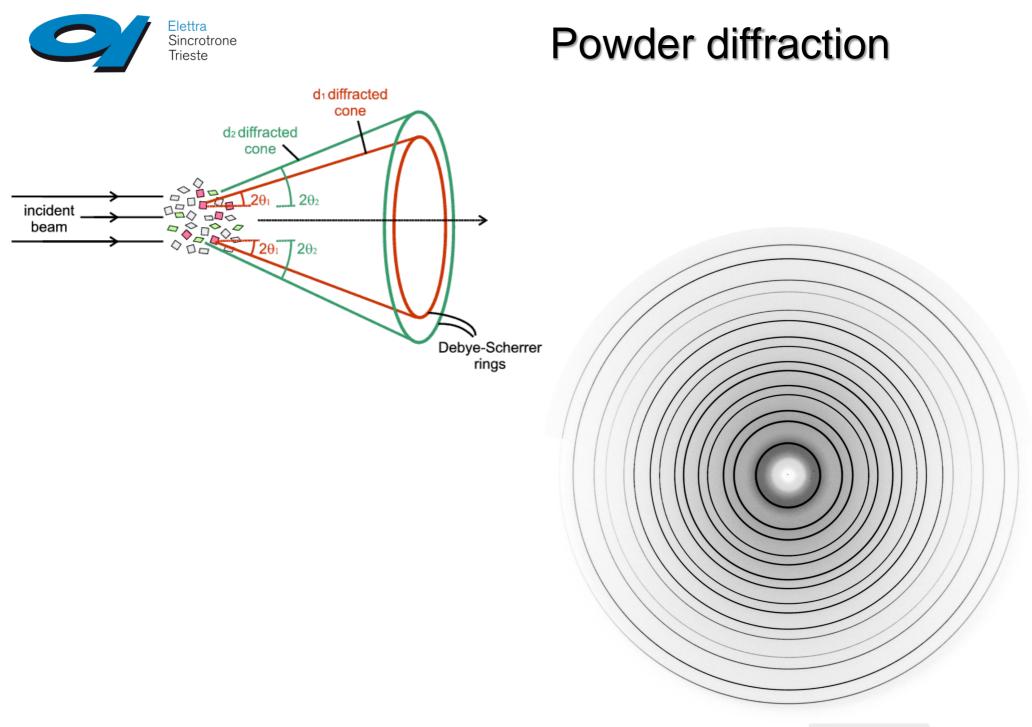




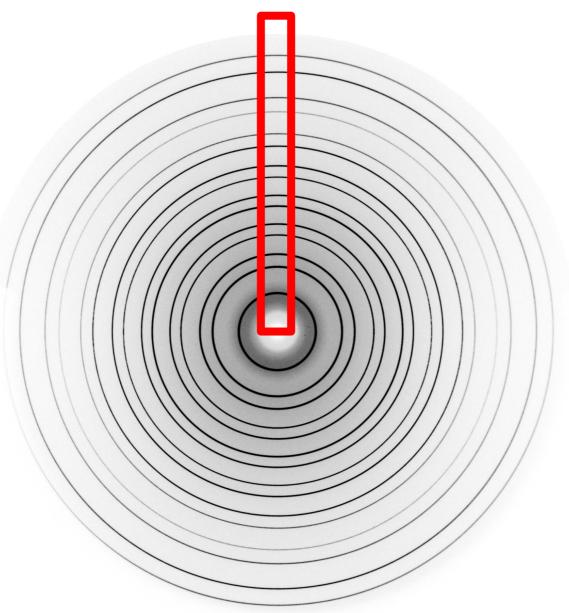




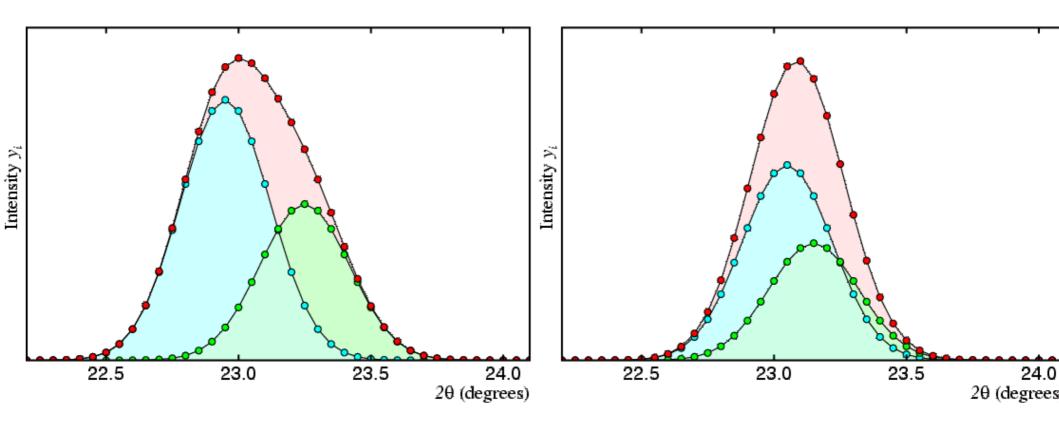






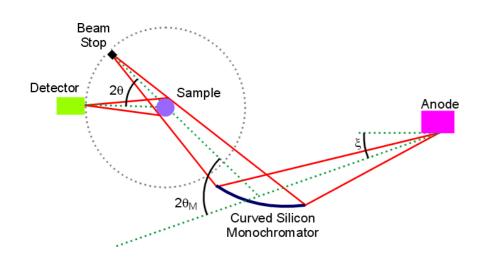


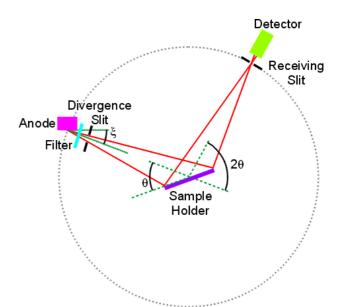






## **Diffraction geometries**

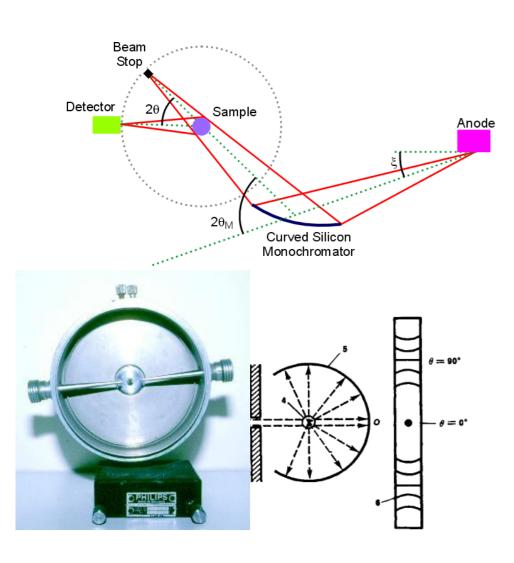


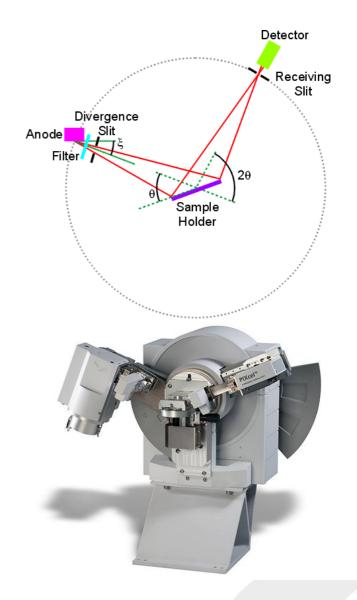


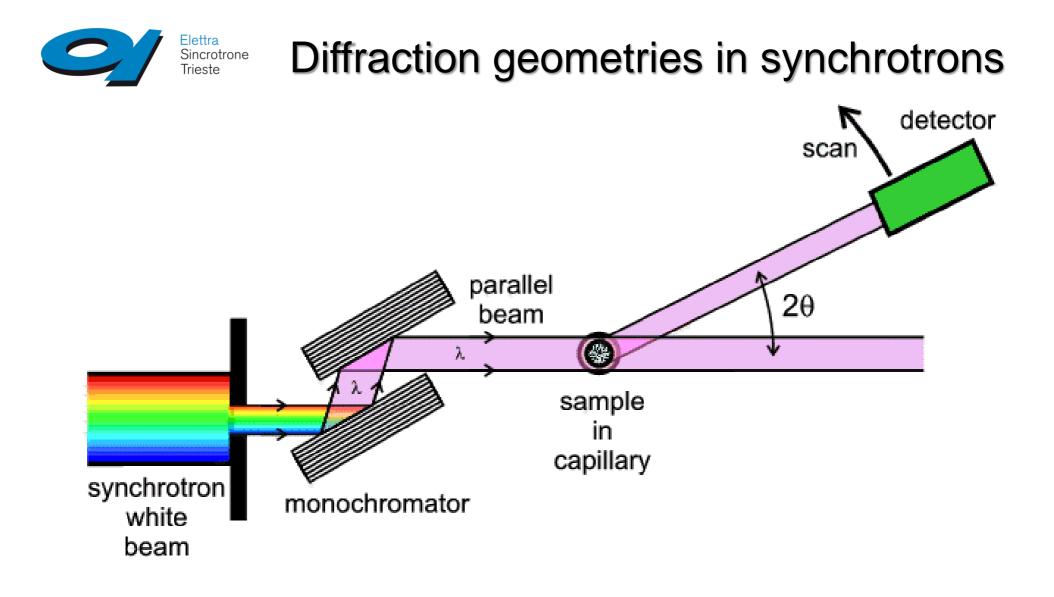
Debije-Scherrer Transmission Bragg-Brentano Reflection



# **Diffraction geometries**

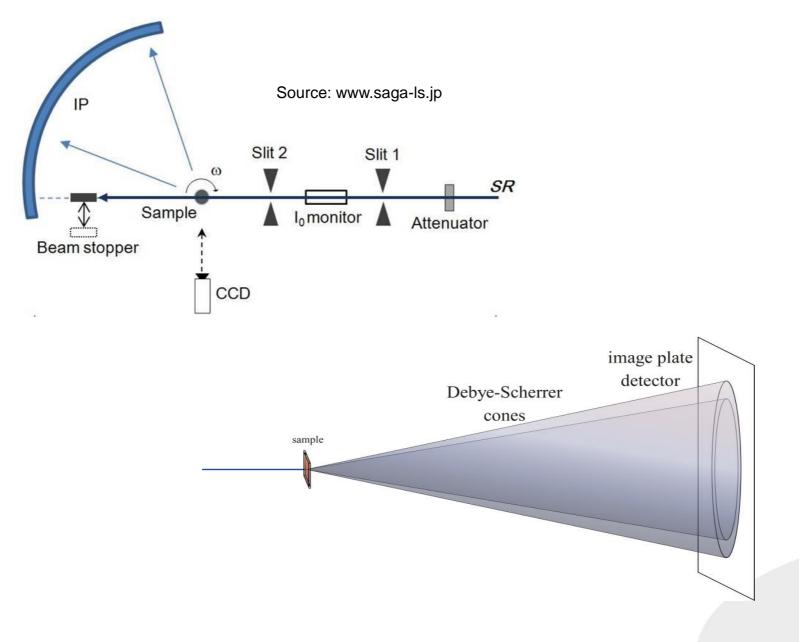


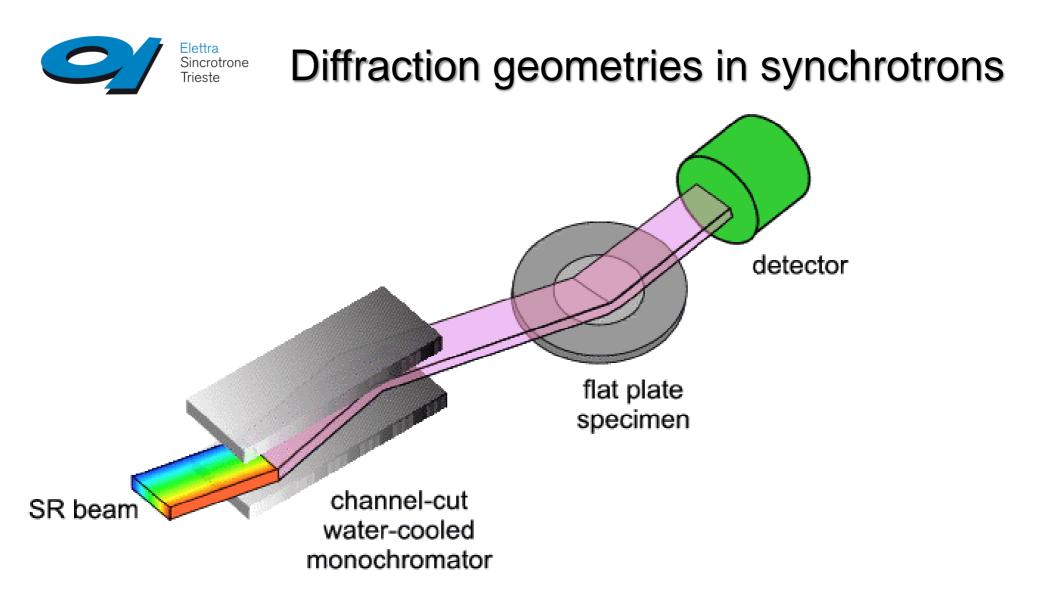






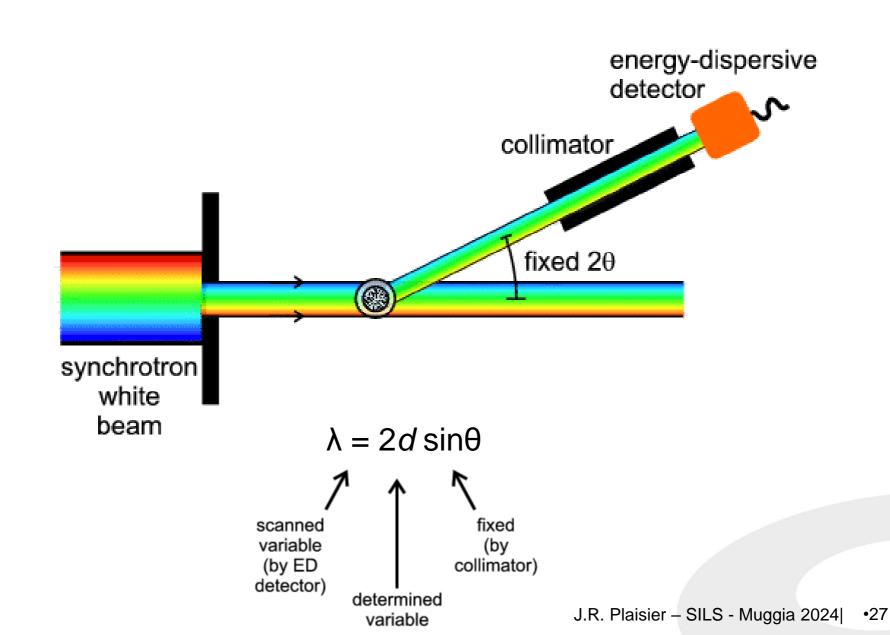
# Diffraction geometries in synchrotrons







# Diffraction geometries in synchrotrons





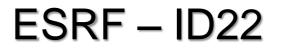
# Advantages of XPRD at synchrotrons

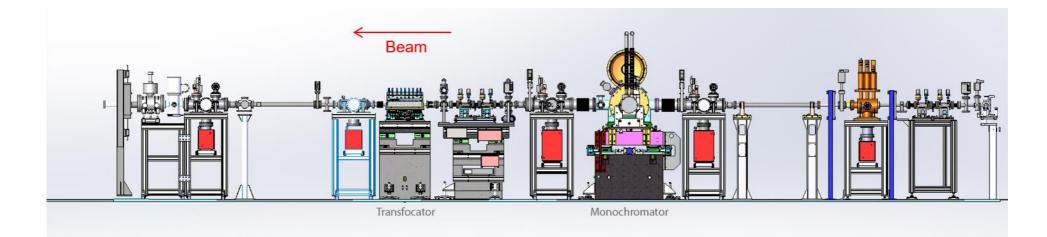
- **High X-ray flux** : Millions count counting statistics in reflection (Bragg-Brentano) as well as in transmission (Debye-Scherrer) modes even with low quantities of powder available
- Highly collimated photon beam: angular resolution better due to narrow instrumental profile. FWHM better than 0.01° 2θ obtained with new generation solid state microstrip detectors and down to 0.002° 2θ using multicrystal analyser detectors
- Tunable photon energy up to high energies:
  - anomalous scattering experiments
  - collect fluorescence-free XRPD data
  - Extension of d-space that can be probed.
  - depth analysis by varying energy



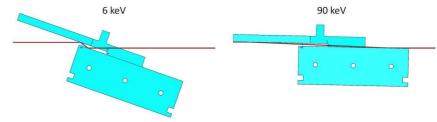
# Instrumentation for X-ray Powder Diffraction at Synchrotrons



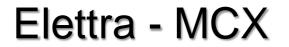




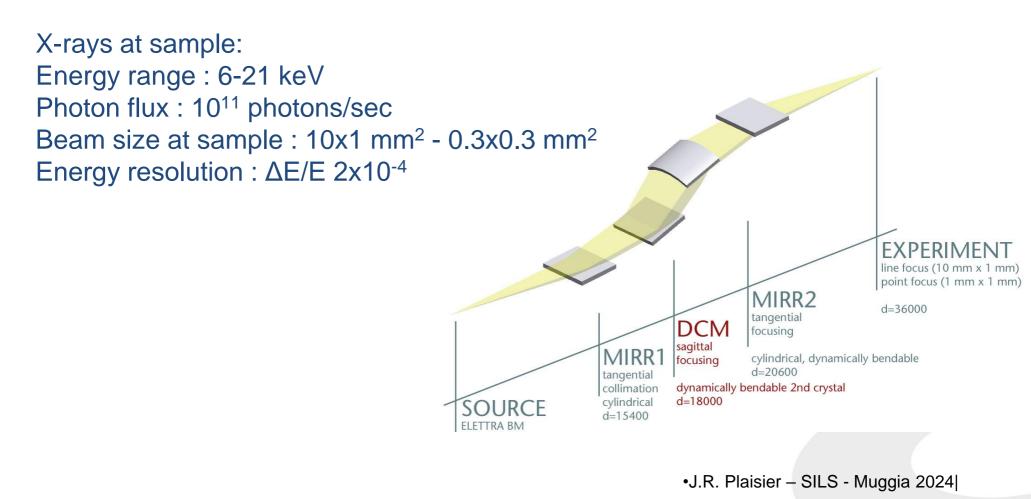
- Light source: In vacuum undulator
- X-rays at **sample:** Energy range : 6-80 keV Beam size can be focused to 50 um







Light source: Bending magnet Critical energy : 3.2keV (2.0) , 5.5keV (2.4)





# **Diffractometer MCX**





## **Diffractometer ID22-ESRF**

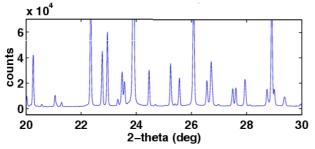




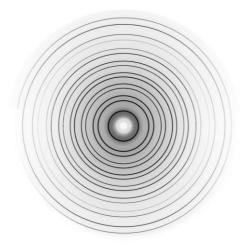


#### 0D – (spot) detectors: Scintillators N

1D – Line detectors: Gas detectors, Strip

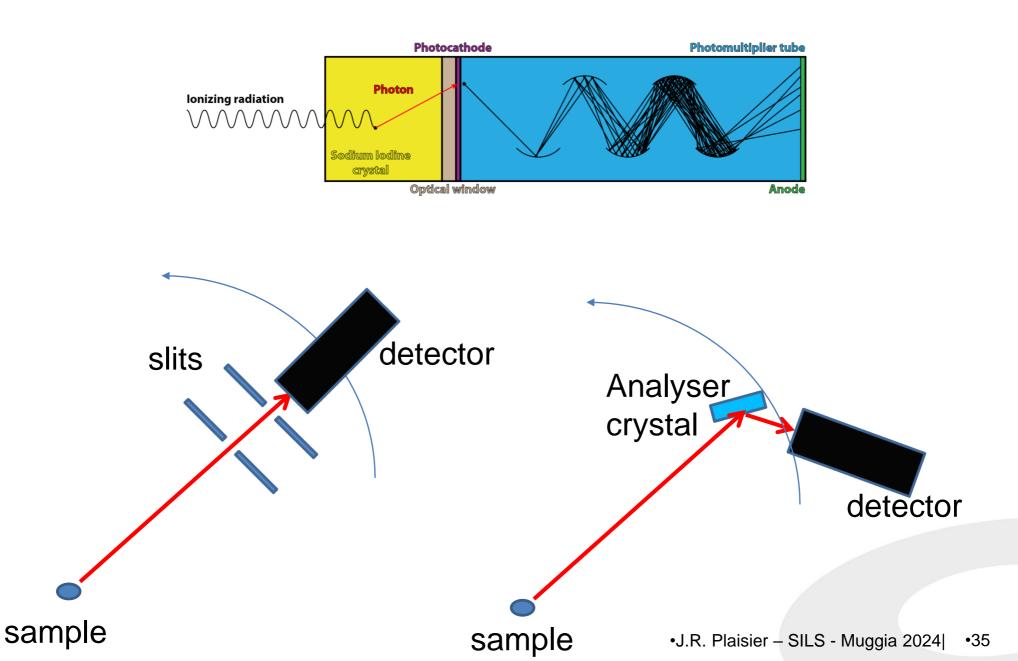


2D -- Area detectors: Image plate, CCD, Pixel



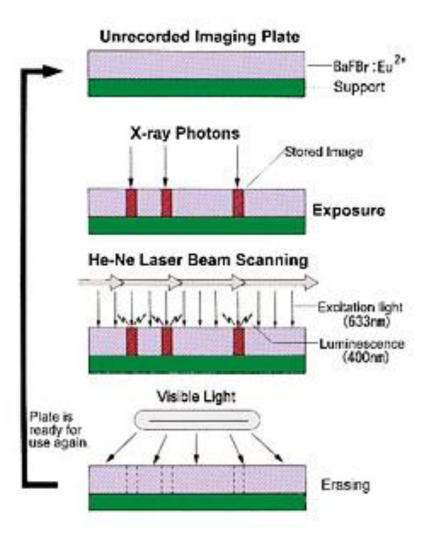


# Scintillator detector (0D)





# Image plate (2D)

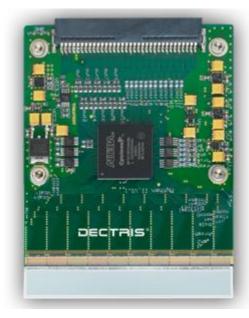


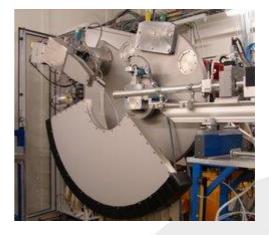




# Mythen detector (1D)





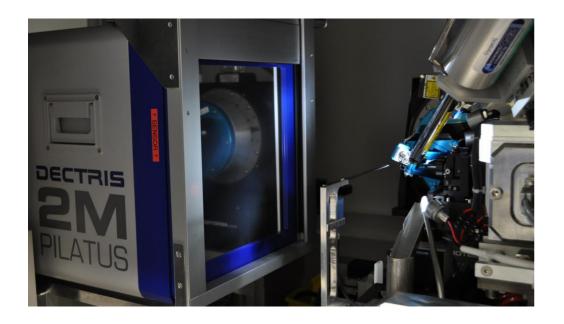


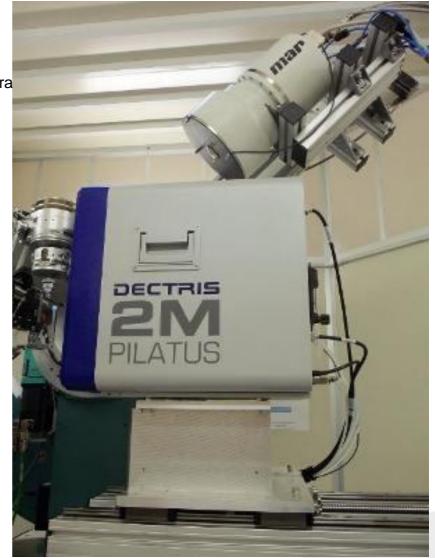




Source: XRD1 - elettra

Source: www.psi.ch



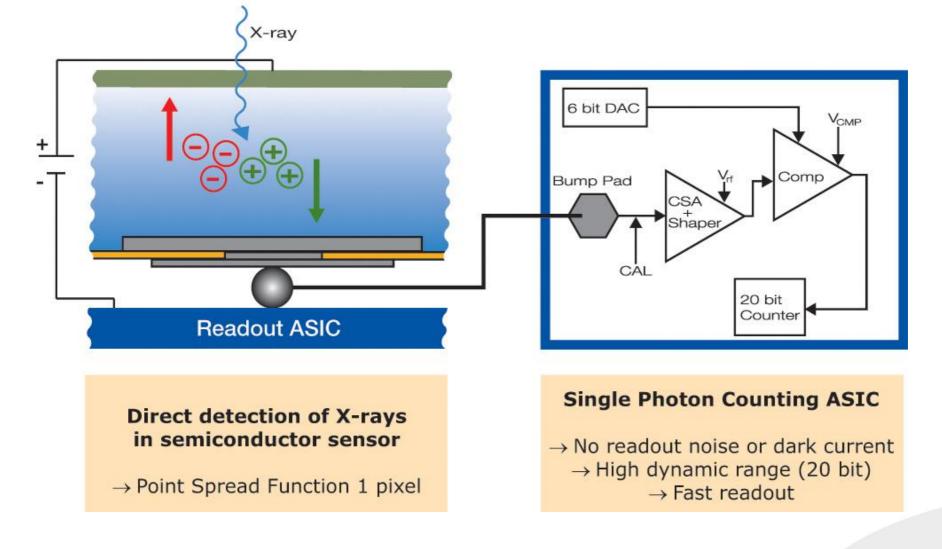




**Sensor Pixel** 

# Pilatus detector (2D)

#### **Readout Pixel**





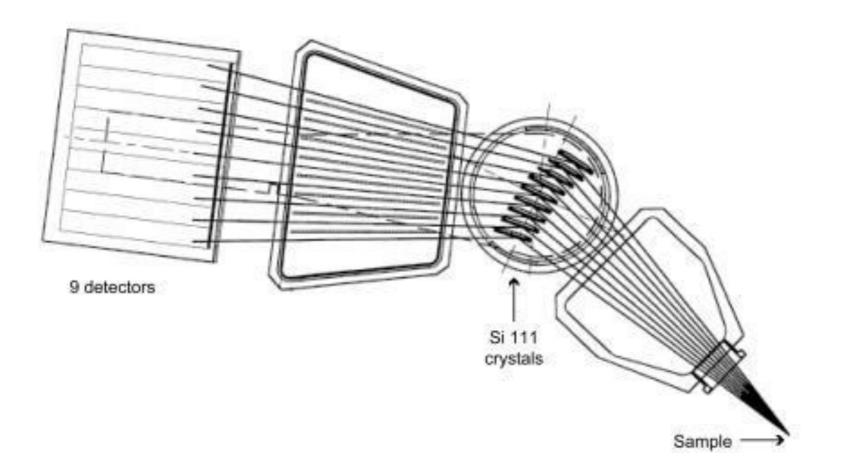
# Mythen (1D) and Pilatus (2D)

Silicon
Reverse biased pn- junction array
Single photon counting
320, 450, 1000
1280
64 x 8
50 x 8000
0.3
>1x10 <sup>6</sup>
5 – 40
1 channel
4, 8, 16, 24 (1 : 16777216)

Sensor material	Silicon
Sensor	Reverse biased pn-junction array
Detection principle	CMOS hybrid-pixel technology - single photon counting
Sensor thickness [µm]	320
Number of pixels/module	1475 x 1679 = 2476525 pixels
Sensitive area (width x length) [mm <sup>2</sup> ]	254 x 289
Dimensions of one pixel (width x length) [µm <sup>2</sup> ]	172 x 172
Read out time [ms]	3.6 (frame rate 30Hz)
Maximum count rate per channel [X-rays/s]	>1x10 <sup>6</sup>
Energy range [keV]	3 - 30 keV (quantum efficiency: 3 keV 80%; 8 keV 99%; 15 keV 55%)
Point-spread function	1 pixel

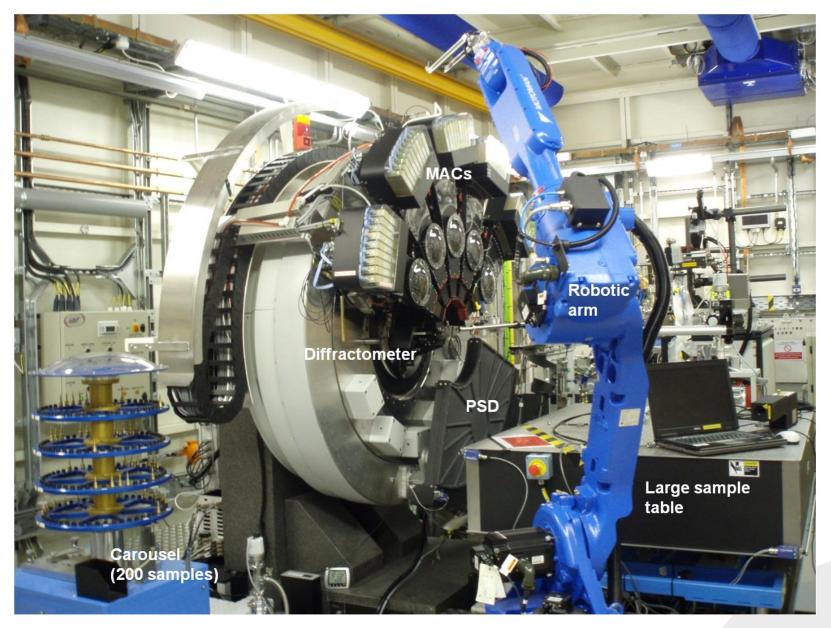


#### **Diffractometer ID22-ESRF**



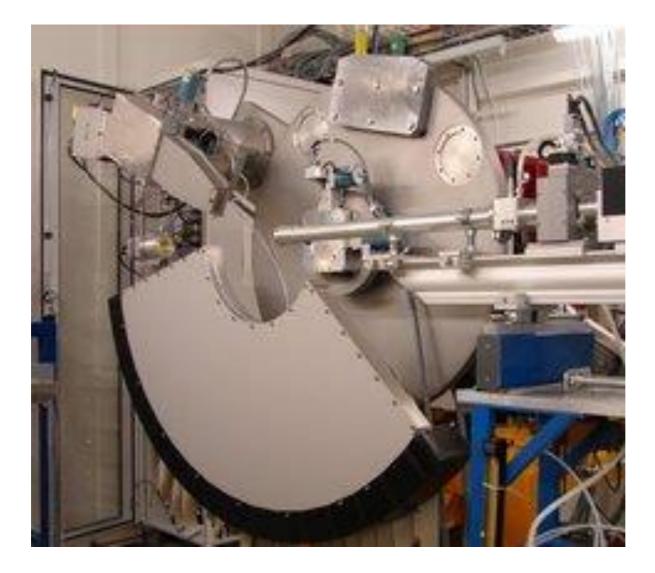


#### **Diffractometer I11 - Diamond**





#### **Diffractometer MS**





# Information from Powder Diffraction



# Information from powder diffraction

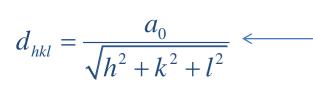
- The diffraction peak positions give information on the size and shape of the unit cell.
- Shifts in peak positions give information about deformation (eg. Residual stress)

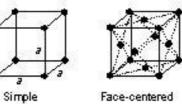
$$\lambda = 2d \sin\theta$$

$$\frac{1}{d_{hkl}^{2}} = h^{2} \frac{b^{2}c^{2} \sin^{2} \alpha}{V^{2}} + k^{2} \frac{a^{2}c^{2} \sin^{2} \beta}{V^{2}} + l^{2} \frac{a^{2}b^{2} \sin^{2} \gamma}{V^{2}} + 2hk \frac{abc^{2}(\cos \alpha \cos \beta - \cos \gamma)}{V^{2}} + 2kl \frac{a^{2}bc(\cos \beta \cos \gamma - \cos \alpha)}{V^{2}} + 2lh \frac{ab^{2}c(\cos \gamma \cos \alpha - \cos \beta)}{V^{2}}$$



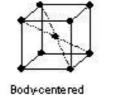
# Information from powder diffraction

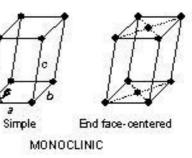


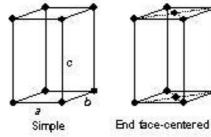


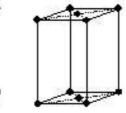
CUBIC

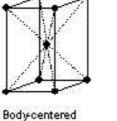
ORTHORHOMBIC





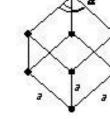




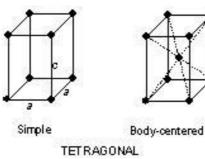


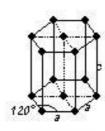




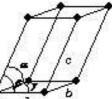


RHOMBOHEDRAL

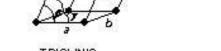








TRICLINIC





• The Intensity of a diffracted beam,  $I_{hkl}$  is related to an imaginary number called the structure factor,  $F_{hkl}$ :  $I_{hkl} \propto |F_{hkl}|^2$ 

$$F(hkl) = \sum_{n} f_n N_n e^{2\pi i (hx_n + ky_n + lz_n)} e^{-Bsin^2\theta/\lambda}$$

- The Intensity of a diffracted beam gives information on the positions of the atoms in the unit cell and hence the 'atomic structure' of the material
- In case of mixtures the intensities give information on the quantity of various materials in the mixture



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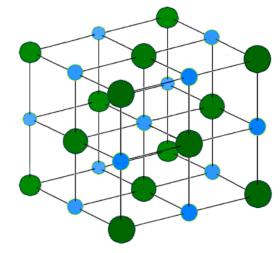
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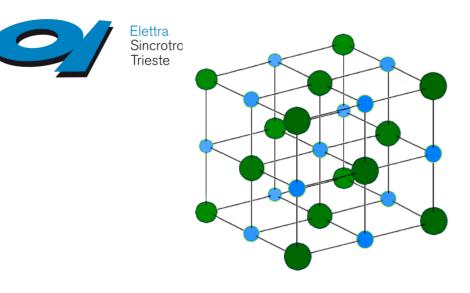
### Structure determination

#### **Steps in structure determination from SR-XRPD:**

- Indexing (DICVOL ecc.)
- Space group determination
- Finding a model structure
  - · Direct methods
  - Simulated annealing etc. (eg. DASH)
  - Model from similar compounds

Refining the structure (Rietveld)

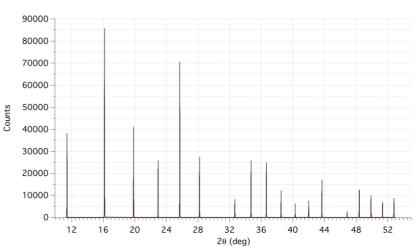




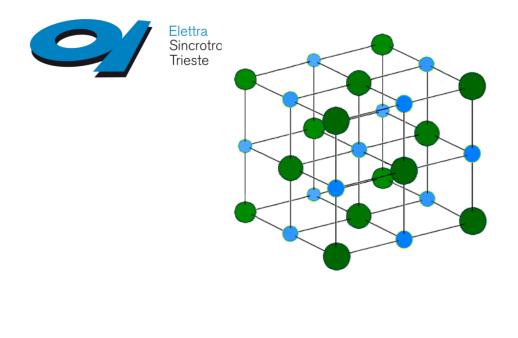
- Known parameters: peak positions
- Unknowns:
  - . Unit cell a,b,c,  $\alpha$ ,  $\beta$ ,  $\gamma$
  - Miller indices: h, k ,lfor each reflection
  - · Zero shift  $(2\Theta_0)$

 $d = \lambda / 2 \sin(\Theta - 2\Theta_0/2)$ 

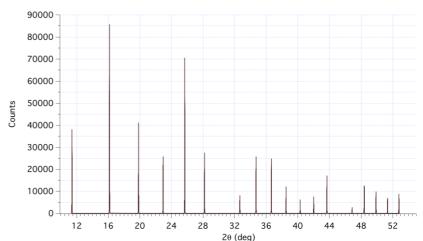
# Structure determination Indexing



$$\frac{1}{d_{hkl}^{2}} = h^{2} \frac{b^{2}c^{2} \sin^{2} \alpha}{V^{2}} + k^{2} \frac{a^{2}c^{2} \sin^{2} \beta}{V^{2}} + l^{2} \frac{a^{2}b^{2} \sin^{2} \gamma}{V^{2}}$$
$$+ 2hk \frac{abc^{2}(\cos \alpha \cos \beta - \cos \gamma)}{V^{2}} + 2kl \frac{a^{2}bc(\cos \beta \cos \gamma - \cos \alpha)}{V^{2}}$$
$$+ 2lh \frac{ab^{2}c(\cos \gamma \cos \alpha - \cos \beta)}{V^{2}}$$



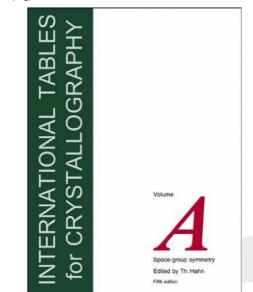
### Structure determination Fining the space group

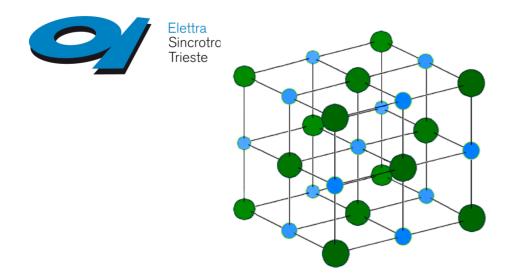


The space group describe the symmetry in the unit cell (e.g. Centering, mirror planes, rotation axes)

Some symmetry elements may cause certain reflections to have zero intensity.

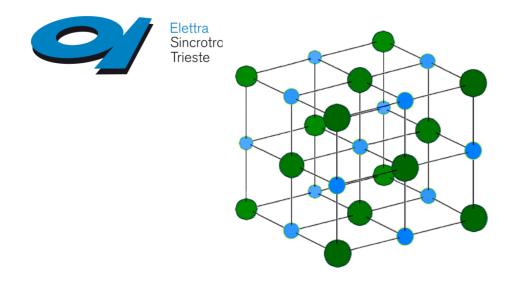
Indentifying these reflection conditions allows to identify the proper space group candidates.





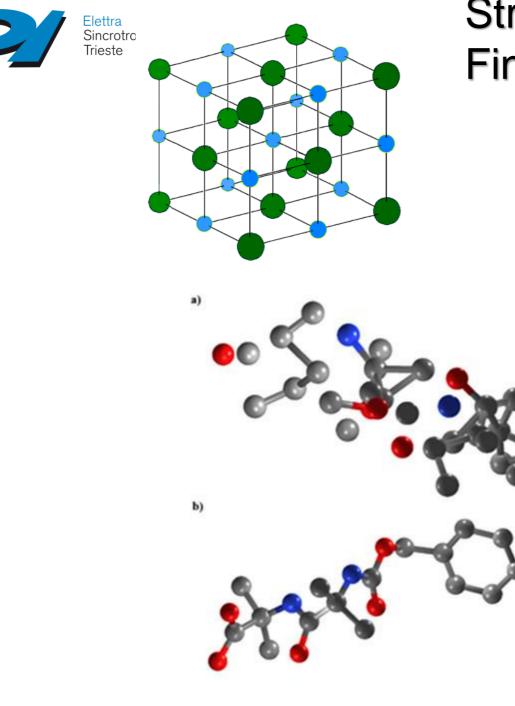
### Structure determination Finding the space group

Unit-Cell Geometry	Inferred Crystal System(s)	No. of Space Groups
$a \neq b \neq c$ and $\alpha \neq \beta \neq \&$ gamma; & ne; 90°	Triclinic	2
$a \neq b \neq c$ and $\alpha = \gamma = 90^{\circ}$ and $\beta \neq 90^{\circ}$	Monoclinic	13
$a \neq b \neq c \text{ and } \alpha = \beta = \gamma = 90^{\circ}$	Orthorhombic	59
$a = b \neq c \text{ and } \alpha = \beta = \gamma = 90^{\circ}$	Tetragonal	68
$a = b = c$ and $\alpha = \beta = \gamma \neq 90^{\circ}$	Trigonal (Rhombohedral)	7
$a = b \neq c$ and $\alpha = \beta = 90^{\circ}$ and $\gamma = 120^{\circ}$	Trigonal or Hexagonal	45
$a = b = c$ and $\alpha = \beta = \gamma = 90^{\circ}$	Cubic	36



### Structure determination Finding the space group

Reflection Condition(s)		Possible Space Group(s)		
None	$\rightarrow$	P2 Pm P2/m	(3) (6) (10)	
0k0: k = 2n	$\rightarrow$	$\begin{array}{c} P2_1\\ P2_1/m \end{array}$	(4) (11)	
h0l: l = 2n	$\rightarrow$	Pc P2/c	(7) ( <b>13</b> )	
h0l: l = 2n  and  0k0: k = 2n	$\rightarrow$	<u>P2<sub>1</sub>/c</u>	(14)	
hkl: h + k = 2n	$\rightarrow$	C2 Cm C2/m	(5) (8) (12)	
hkl: h + k = 2n  and  h0l: l = 2n	$\rightarrow$	Cc C2/c	(9) (15)	

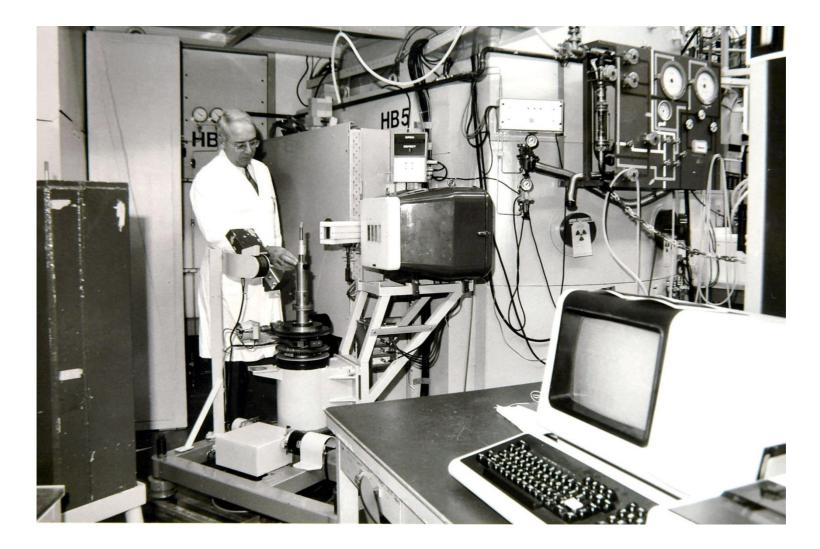


# Structure determination Finding a starting model

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#### **Structure Determination**





#### Parameters refined in Rietveld refinement:

- Background (fixed, functions)
- Peak shape (microstructural parameters, functions)
- Lattice constants Zero pont correction Sample displacement
- Scaling phase fractions
- Structural parameters (Atoms positions, occupancies, B)
- Preferred orientation
- Absorption

Parameters are adjusted, and a diffraction pattern is calculated until the best fit wih the measured pattern is obtained



#### Structure determination

$$F(hkl) = \sum_{n} f_n N_n e^{2\pi i (hx_n + ky_n + lz_n)} e^{-Bsin^2\theta/\lambda}$$

$$|(hkl) \sim |F(hkl)|^2$$

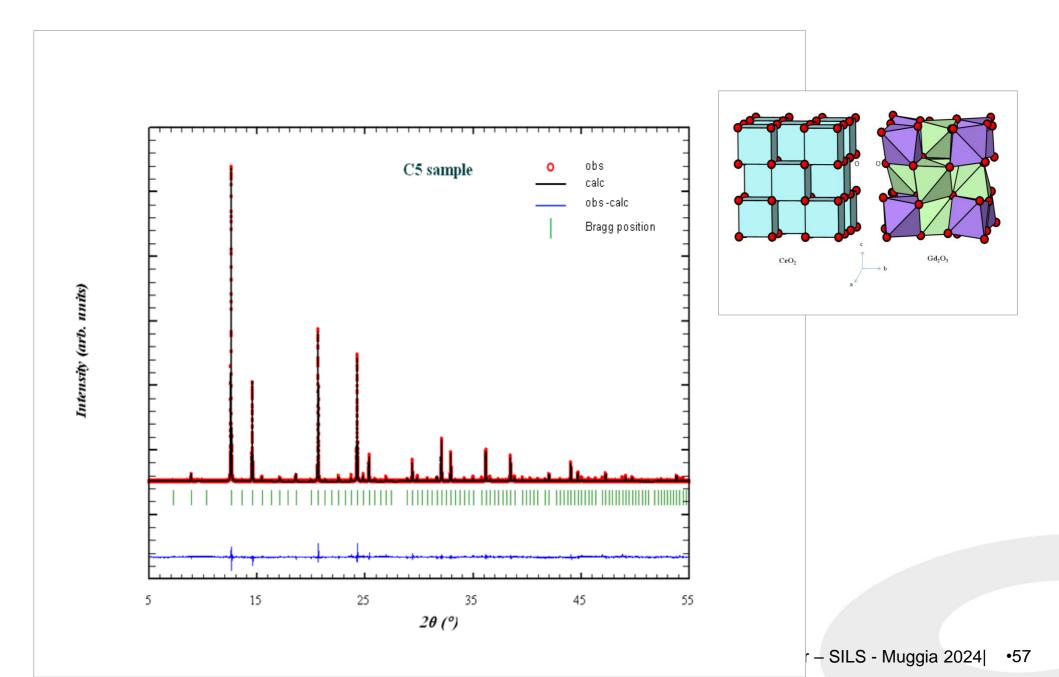
$$y_i = I_k \exp \left[rac{-4\ln(2)}{H_k^2}(2 heta_i-2 heta_k)^2
ight]$$

$$H_k^2 = U \tan^2 heta_k + V \tan heta_k + W$$

$$M = \sum_i W_i igg\{ y_i^{obs} - rac{1}{c} y_i^{calc} igg\}^2$$



#### Structure determination





# Information from powder diffraction

- **1895** Rontgen discovered X-rays
- **1912** Laue measured the first diffraction pattern of crystal
- **1913** Braggs published first crystal structures
- **1918** Paul Scherrer published the Scherrer formula to determine the size of nanocrystals



Information from powder diffraction

$$B(2\theta) = \frac{K\lambda}{L\cos\theta}$$

• Peak width (B) is inversely proportional to the nanocrystal size (L).

P. Scherrer, "Bestimmung der Grösse und der inneren Struktur von Kolloidteilchen mittels Röntgenstrahlen," *Nachr. Ges. Wiss. Göttingen* **26** (1918) pp 98-100.



• The shape of the peak give information about the microstructure of the materials

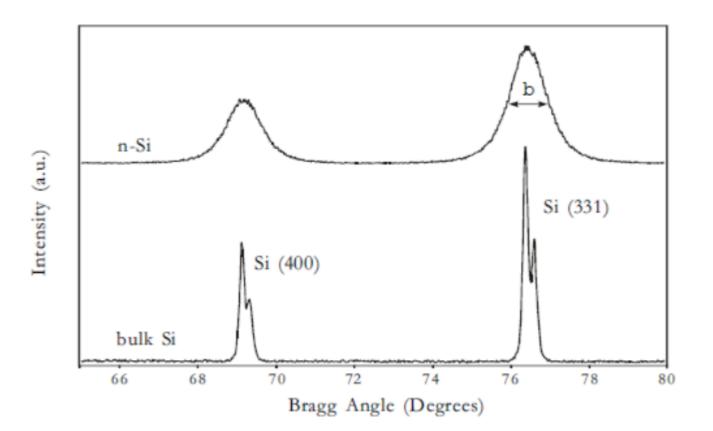
A diffraction peak is a **convolution** () of *profile components* produced by different sources.

These are instrumental factors (IP) and effects due to domain size (S), microstrain (D), faulting (F), anti-phase domain boundaries (APB), stoichiometry fluctuations (C), grain surfacerelaxation (GSR), etc.

 $\mathbf{I}(s) = \mathbf{I}_{\mathrm{IP}}(s) \otimes \mathbf{I}_{\mathrm{S}}(s) \otimes \mathbf{I}_{\mathrm{D}}(s) \otimes \mathbf{I}_{\mathrm{F}}(s) \otimes \mathbf{I}_{\mathrm{APB}}(s) \otimes \mathbf{I}_{\mathrm{C}}(s) \otimes \mathbf{I}_{\mathrm{GRS}}(s) \dots$ 

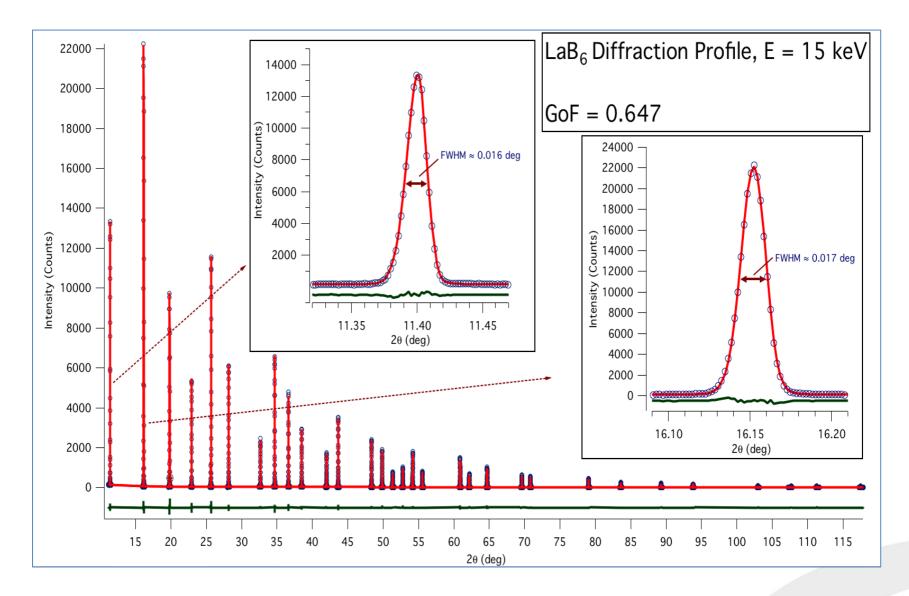


### Information from powder diffraction





### Instrumental profile



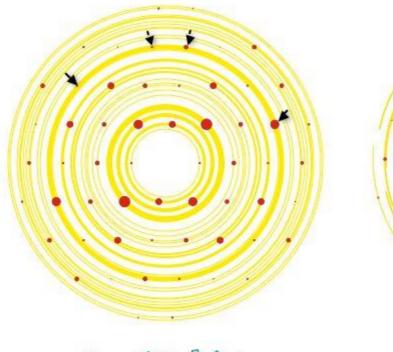


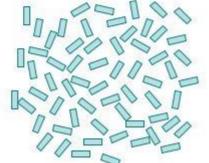
# Obtaining information from XRPD

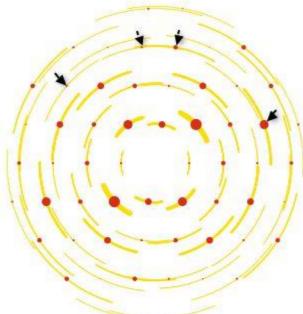
- We want to measure the intensity profile in reciprocal space
  - position of diffraction peaks (d<sub>hkl</sub>)
  - intensity (  $\mathbf{I}_{hkl}$  )
  - peak profile
- **IMPORTANT**: a correct measurement assumes:
  - the homogeneous spatial distribution of the crystallites in the sample
  - the homogeneous probing of the material by the beam
  - the statistically correct measurement of intensity

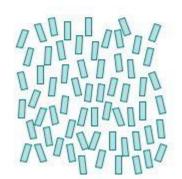








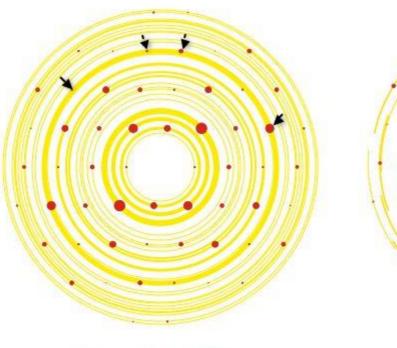


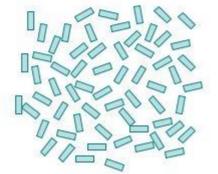


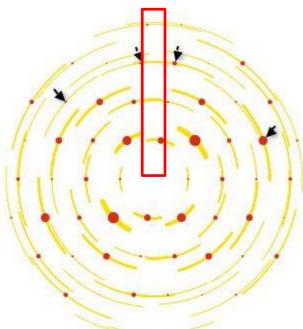
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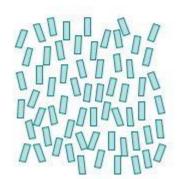






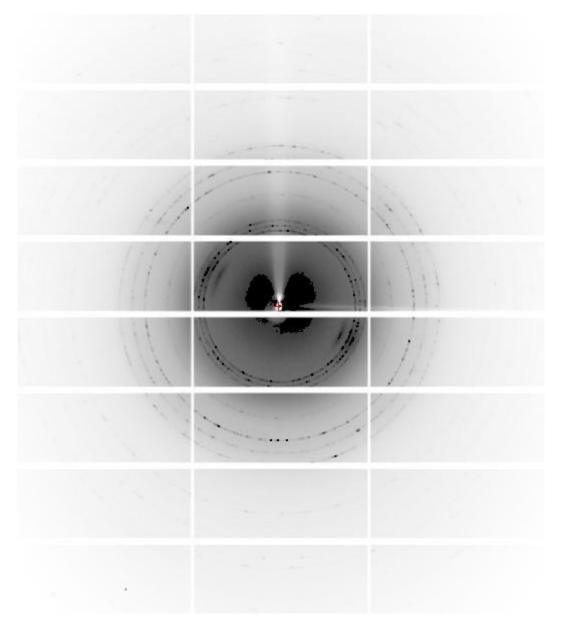






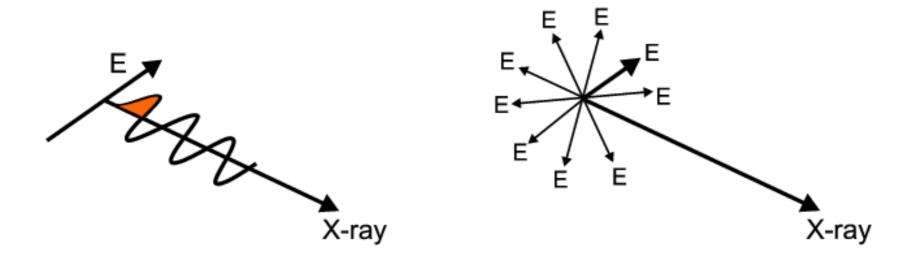


### Few cristallites





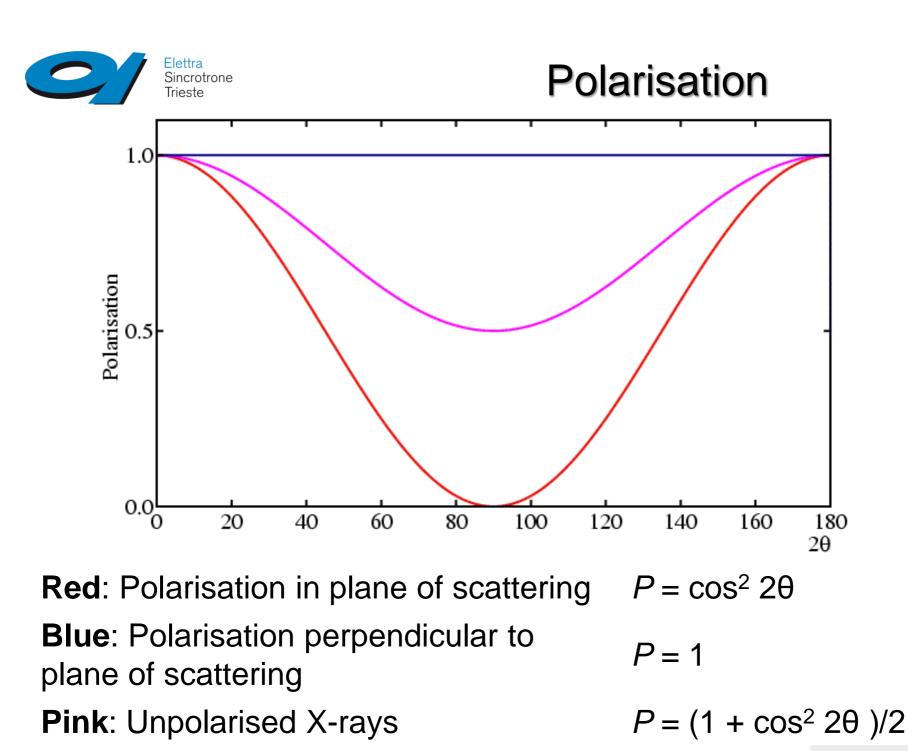




#### Synchrotron

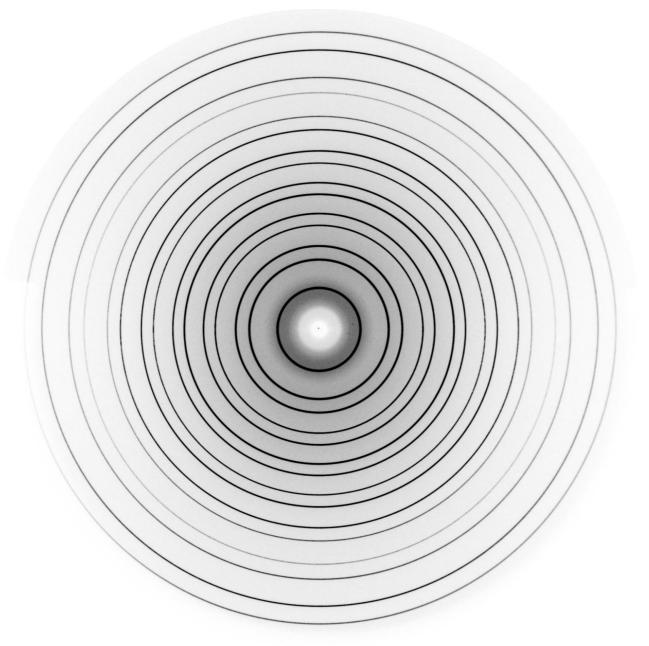
Radiation is horizontally polarised in the plane of the electron orbit

#### Laboratory source Unpolarised radiation



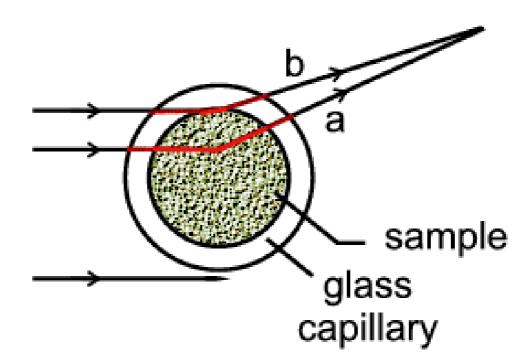








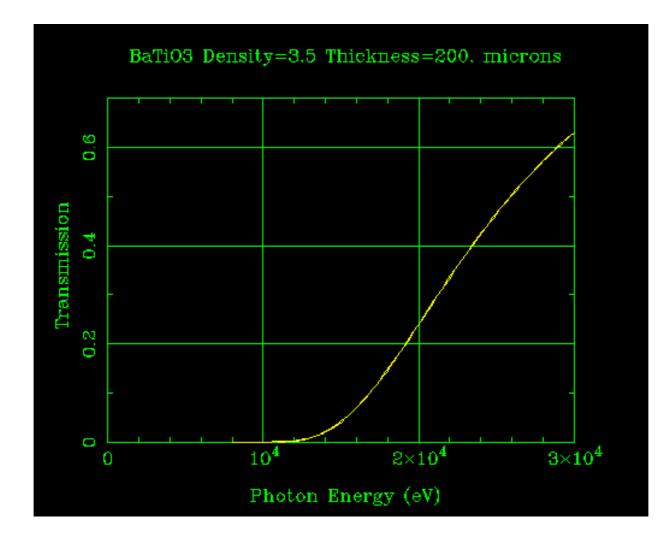




**Capillary:** The effect is not easy to calculate but the result is satisfying. As the example above illustrates, some paths appear to be like transmission (a) and others like reflection (b). Correction for this effect can be made if the absorption of the sample is not too large.

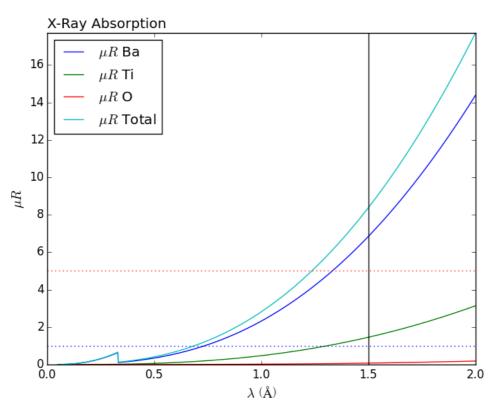


#### Absorption

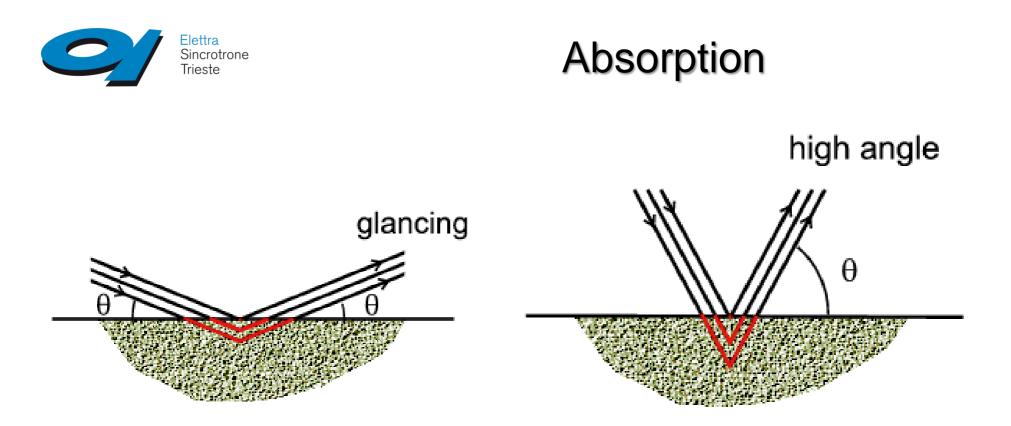








The plot above shows the absorption for each input element and for the specified composition as a function of X-ray wavelength/energy. The blue dotted line indicates a muR value of 1. In a capillary (Debye-Scherrer) geometry, it is ideal when muR is 1 or below, as sample absorption is minimal and no correction is usually needed. The red dotted line indicates a muR value of 5. For muR >= 5, measurements are generally not possible in a capillary geometry, as there will be very severe levels of absorption and corrections are inaccurate. (source: http://11bm.xray.aps.anl.gov/absorb/absorb.php)



**Bragg-Brentano:** The effect might not be so obvious how to calculate but result is that when all the possible path lengths are taken in to account, the net absorption remains constant with  $\theta$ . This means that the effect of absorption can effectively be ignored in this case since it affects all reflections equally. Therefore this geometry may be an alternative when dealing with strongly absorbing samples



## Applications of XRPD

- Phase identification (search match procedures)
- Crystal structure determination (ab initio solution and refinement)
- Quantitative Phase Analysis (QPA)
- Amorphous phase analysis and total Scattering PDF analysis
- Crystalline domain size/shape and lattice defect analysis (LPA)
- Determination of preferred orientations (Texture Analysis)
- Residual Stress Analysis
- ... and more



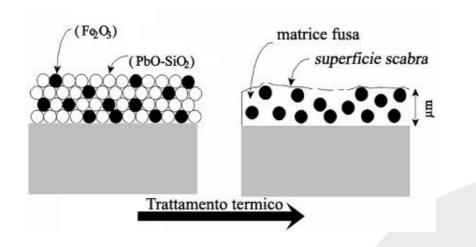


windows



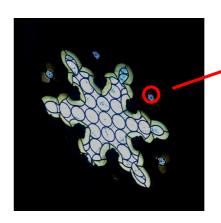
### **Glass samples: Grisaille**

- Low melting glass (SiO<sub>2</sub>, PbO,)
- Pigment (metal oxides)
- Paint medium (water, vinegar, oil)
- Firing to fuse the grisaille on the glass



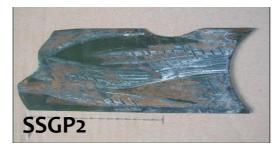






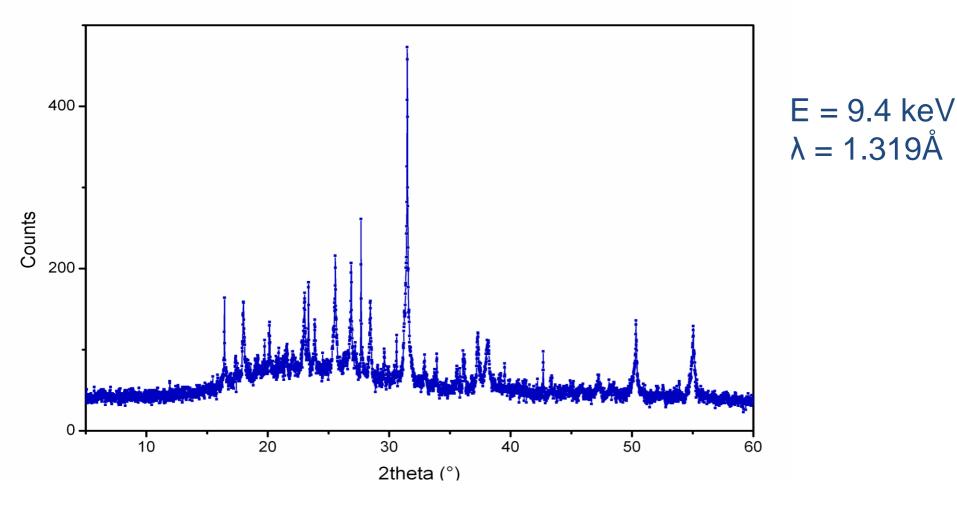
SSGP3



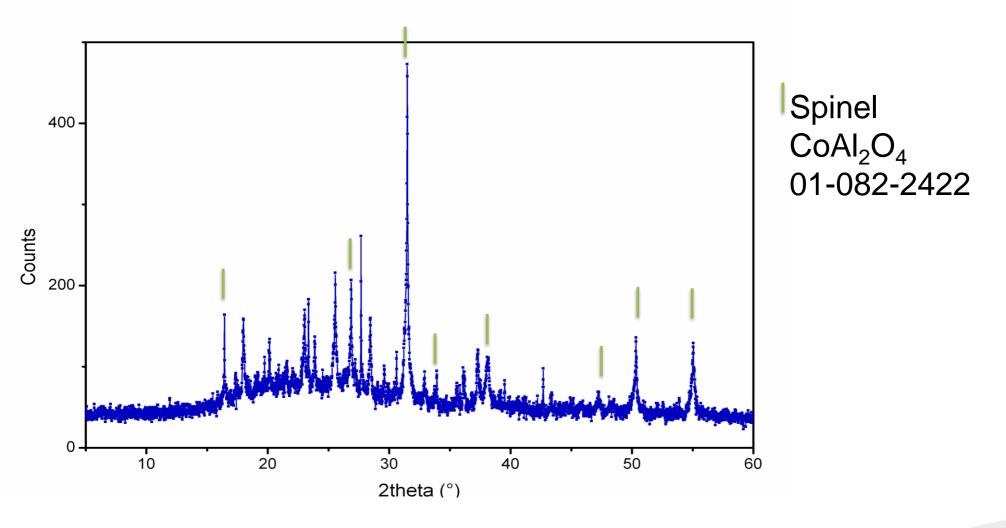




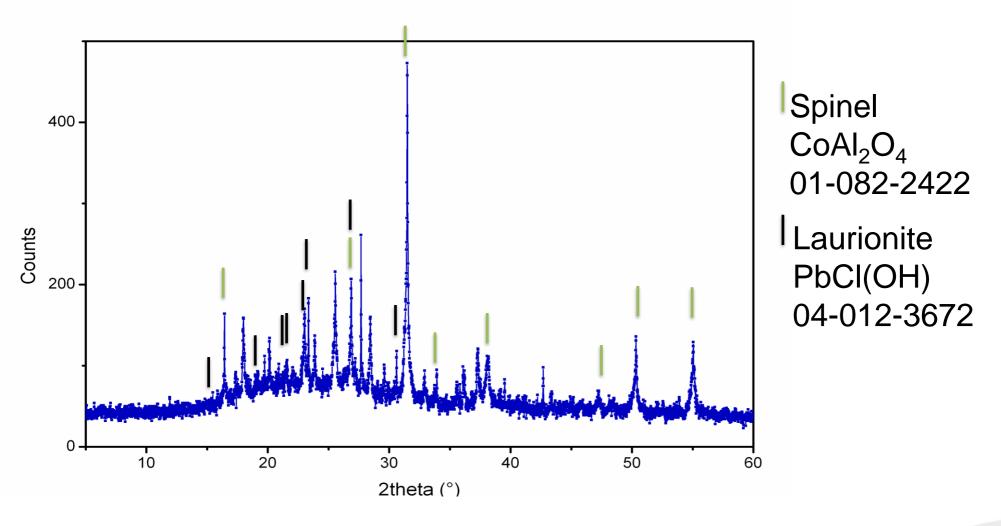




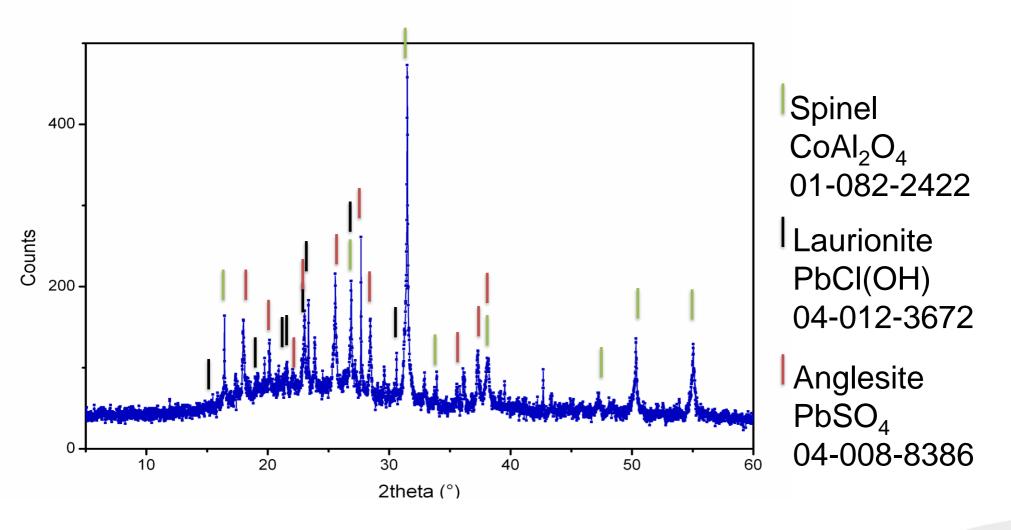














### **GRISAGLIA**





CoAl<sub>2</sub>O<sub>4</sub>; PbSO<sub>4</sub>; Pb(OH)Cl Amorphous



$$Pb_2Sb_2O_7; PbSO_4;$$
  
CaSO<sub>4</sub>(H<sub>2</sub>O)<sub>2</sub>; CaAl<sub>2</sub>Si<sub>2</sub>O<sub>8</sub>

FeO(OH); FeSO<sub>4</sub>(OH)(H<sub>2</sub>O)<sub>2</sub> PbSO<sub>4</sub>; CaSO<sub>4</sub>(H<sub>2</sub>O)<sub>2</sub>; Al<sub>2</sub>Si<sub>2</sub>O<sub>5</sub>(OH)<sub>4</sub>



 $CoAl_2O_4$ ; PbSO<sub>4</sub>; CaPO<sub>3</sub>(OH)<sub>2</sub>H<sub>2</sub>O

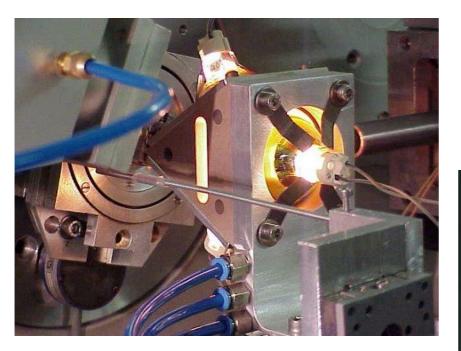
SiO<sub>2</sub>; PbS; PbSO<sub>4</sub>; CaCO<sub>3</sub> (vat)<u></u> CaPO<sub>3</sub>( OH )<sub>2</sub>H<sub>2</sub>O



- Pb<sub>2</sub>Sb<sub>2</sub>O<sub>7</sub>: original pigment
- SO<sub>4</sub><sup>2-</sup>, S<sup>2-</sup>, CO<sub>3</sub><sup>2-</sup>: alteration product seawater-aerosol, acid rain
- FeO(OH); FeSO<sub>4</sub>(OH)(H<sub>2</sub>O)<sub>2</sub> : alteration product of original pigments
- CO<sub>3</sub><sup>2-</sup>,PO<sub>3</sub><sup>3-</sup>: biological origin
- **CoAl<sub>2</sub>O<sub>4</sub>** : intervention at later date?



## XRPD in non ambient conditions

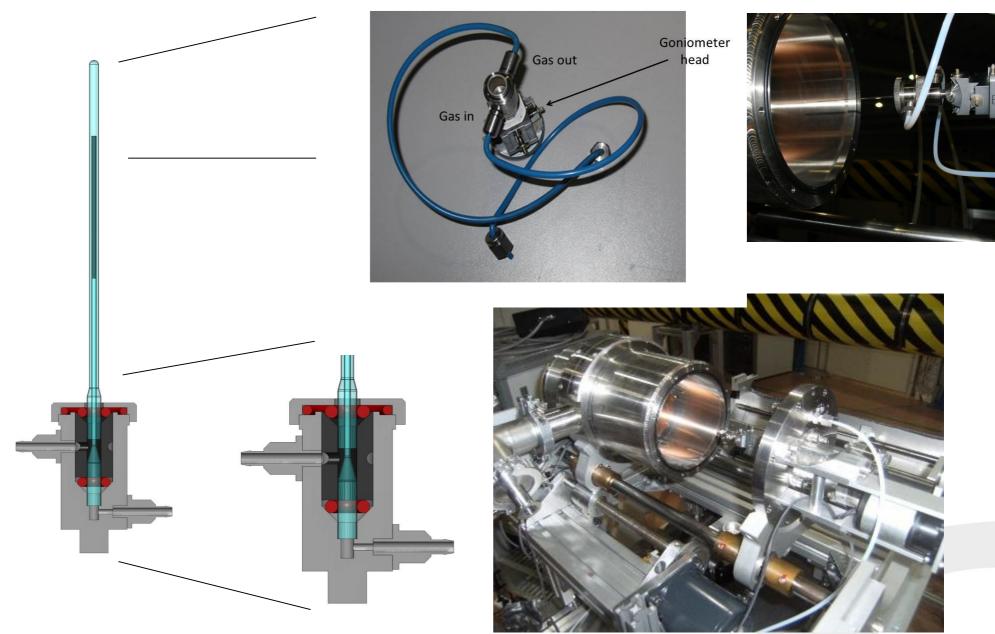




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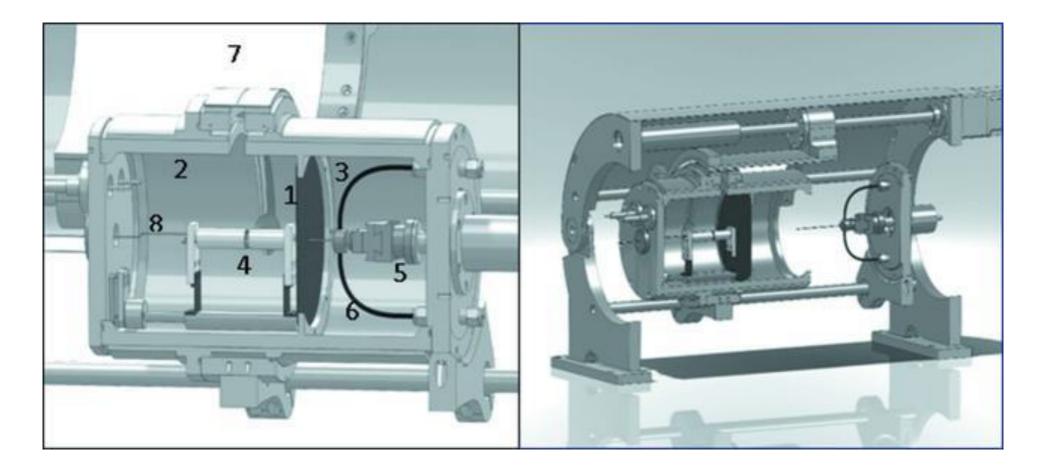


## XRPD in non ambient conditions





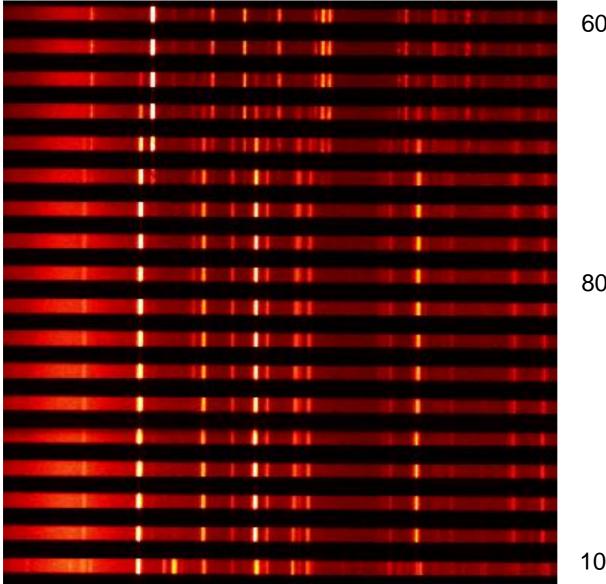
## **Furnace Design**



In situ reaction furnace for real-time XRD studies Riello P., Lausi A., MacLeod J., Plaisier J.R., Zerauschek G., Fornasiero P. *Journal of Synchrotron Radiation, Vol. 20 - 1, pp. 194-196 (2013)* 



## XRPD in non ambient conditions



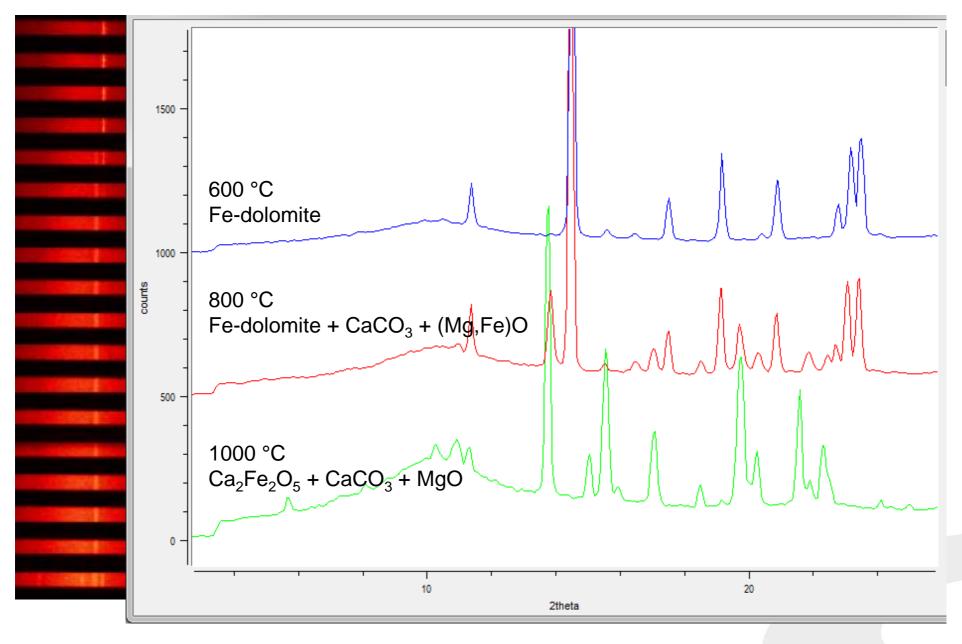
600 °C

800°C

1000 °C



## XRPD in non ambient conditions



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- Phase transitions between 2D (layered) and 3D (cubic) phases in Cu<sub>x</sub>TiS<sub>2</sub> (x = 0-0.5) intercalation compounds have been studied *in situ* by the X-ray diffraction technique in the temperature range 20–1000 °C.
- The discovery of CDW (charge density wave) quantum states and superconductivity in the Cu–TiSe<sub>2</sub> system arouses interest to isostructural materials, but known phase transformations to the spinel structure make comparison difficult.
- Samples were prepared by intercalation of Cu at room temperature. All samples had the layered hexagonal structure.

**2D-3D transition in Cu–TiS<sub>2</sub> system** Shkvarina EG, Titov AA, Doroschek AA, Shkvarin AS, Starichenko DV, Plaisier JR, Gigli L, Titov AN. *The Journal of Chemical Physics 147, 044712 (2017)* 

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											_
S	S	S	S	S	S	S	S	S	S	S	S
Tim	Tim	Tim	Tim	Tim	Tim	$Ti^{ini}$	Tim	Tim	Tim	Tim	H
S	S	S	S	S	S	S	S	S	S	S	S

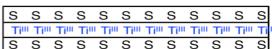
LIT	' Li
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T "#T "#T "#T "#T "#T "#T "#T "#T "#T "#	S	S	S	S	S	S	S	S	S	S	S	S
S S S S S S S S S S S S	Tim	Tim	Tim	Tim	Tjm	Tim	Tim	Tim	Tim	Tim	Tim	Ti
	S	S	S	S	S	S	S	S	S	S	S	S

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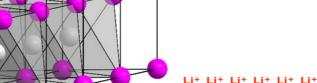
S	S	S	S	S	S	S	S	S	S	S	S
Till	i Tim	$Ti^{III}$	Tim	Tim	Ti						
S	S	S	S	S	S	S	S	S	S	S	S

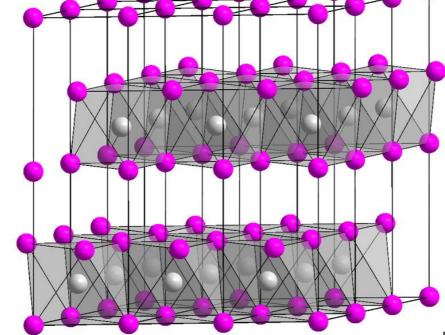
S	S	S	S	S	S	S	S	S	S	S	s
Tim	Ti										
S	S	S	S	S	S	S	S	S	S	S	s





### 





S S

S

S

+Li discharge

-Li

charge

S S

S S

> S S

SSSSS

S S S S

van der Waals gap

SSSSSSSSS

S S S S S S S S S S S

S S S S S S S

van der Waals gap

S S S S S S S S S

TIV TIV TIV TIV TIV TIV TIV TIV TIV TIV

S S S S

S S

S

S

S S S S S

S

S

S

TiS<sub>2</sub> layer

TiS<sub>2</sub> layer

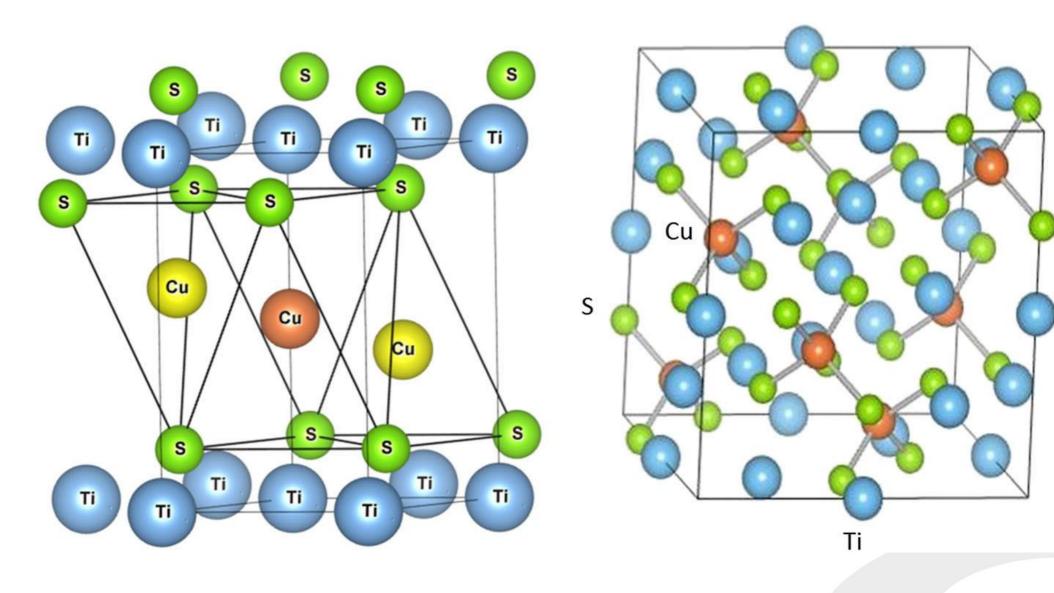
TiS<sub>2</sub> layer



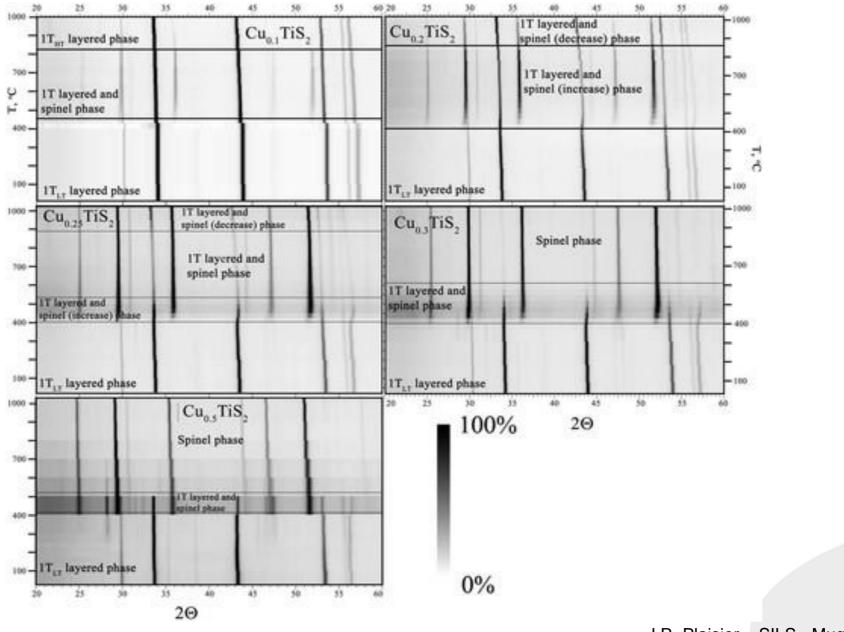
## 2D-3D transition In Cu–TiS<sub>2</sub> system

•90





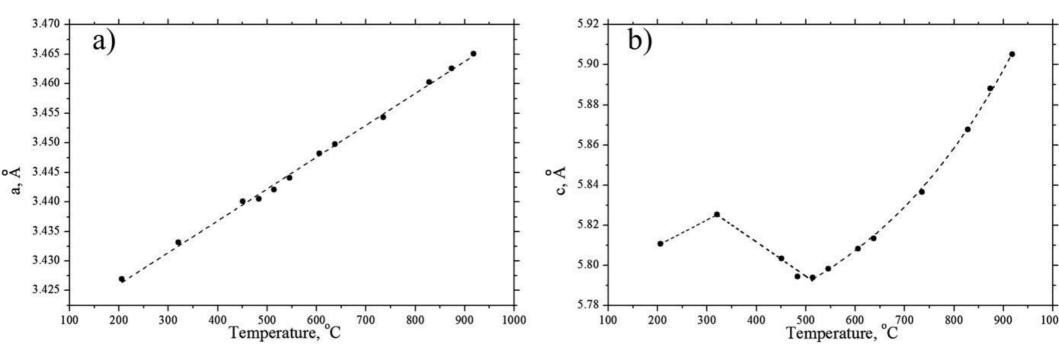


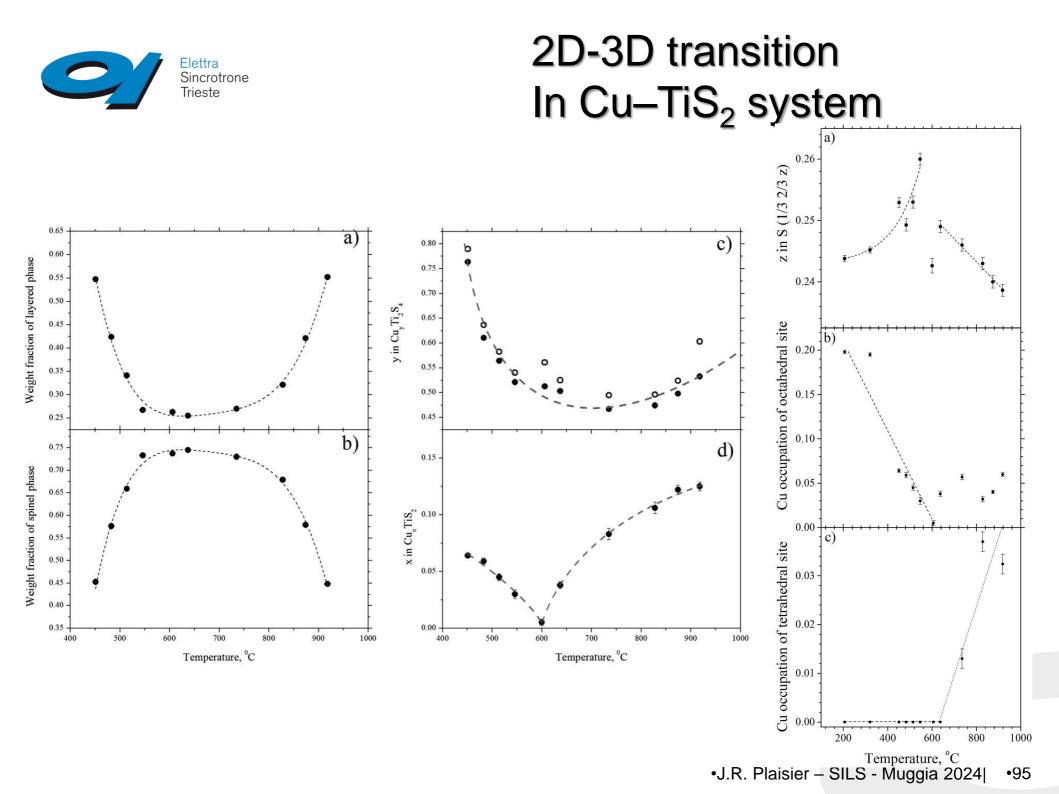




Г (°С)				IT layered pha	Cu	${R_F}^2(\%)$	$\chi^2$					
( -)	а	с	S (1/3 2/3 z)	Cu (0 0 ½)	Cu (	1/3 2/3 z)	Ti (0 0 ½)	a	Cu (1/81/81/8)	S (x x x)		
			z	Occupation	z	Occupation	Occupation		Occupation	x		
						Cu <sub>0.2</sub> TiS <sub>2</sub>						
206	3.4269(1)	5.8106(2)	0.2438(5)	0.198(2)							5.96	1.88
320	3.4331(1)	5.8252(2)	0.2452(5)	0.195(2)							6.44	1.68
451	3.4401(1)	5.8037(2)	0.2593(8)	0.064(2)			0.005(3)	9.9816(4)	0.763(8)	0.2502(5)	3.90	1.12
483	3.4405(1)	5.7942(3)	0.249(1)	0.059(3)				9.9631(3)	0.611(5)	0.2526(3)	2.89	1.13
514	3.4421(1)	5.7937(3)	0.253(1)	0.045(3)			0.017(4)	9.9592(2)	0.564(4)	0.2530(2)	3.18	1.06
546	3.4441(1)	5.7982(4)	0.260(1)	0.030(4)			0.018(5)	9.9604(2)	0.521(3)	0.2529(3)	2.78	1.13
606	3.4482(1)	5.8083(4)	0.243(1)	0.005(3)			0.074(6)	9.9642(1)	0.512(3)	0.2536(2)	4.55	1.10
537	3.4498(1)	5.8133(4)	0.249(1)	0.038(3)			0.018(5)	9.9660(1)	0.503(3)	0.2532(1)	1.86	1.10
735	3.4543(1)	5.8365(4)	0.246(1)	0.057(3)	0.45(3)	0.013(2)	0.020(5)	9.9726(1)	0.467(3)	0.2538(2)	2.89	1.56
828	3.4603(1)	5.8677(3)	0.243(1)	0.032(3)	0.454(7)	0.037(2)	0.029(4)	9.9846(1)	0.474(3)	0.2536(2)	2.72	1.29
874	3.4626(1)	5.8881(2)	0.240(1)	0.040(2)	0.431(6)	0.041(2)	0.031(4)	9.9908(1)	0.498(4)	0.2535(2)	2.92	1.77
918	3.4654(1)	5.9051(3)	0.239(1)	0.060(2)	0.445(8)	0.032(2)	0.001(4)	9.9662(4)	0.533(6)	0.2540(3)	4.12	2.41
						Cu <sub>0.1</sub> TiS <sub>2</sub>						
525	3.4422(1)	5.7990(2)	0.2460(6)	0.044(2)	0.35(2)	0.013(2)	0.024(3)	9.9701(8)	0.66(2)	0.2547(8)	8.16	5.92
647	3.4494(1)	5.8129(2)	0.2448(6)	0.038(2)	0.37(2)	0.015(2)	0.023(4)	9.9690(4)	0.50(2)	0.2544(6)	7.05	5.81
918	3.4650(1)	5.8691(2)	0.2428(7)	0.055(2)	0.42(2)	0.020(3)	0.002(4)				9.65	10.4
						Cu <sub>0.25</sub> TiS <sub>2</sub>						
918	3.4664(2)	5.9140(8)	0.236(2)	0.009(6)	0.46(1)	0.052(4)		10.0075(1)	0.512(4)	0.2531(2)	6.42	10.8

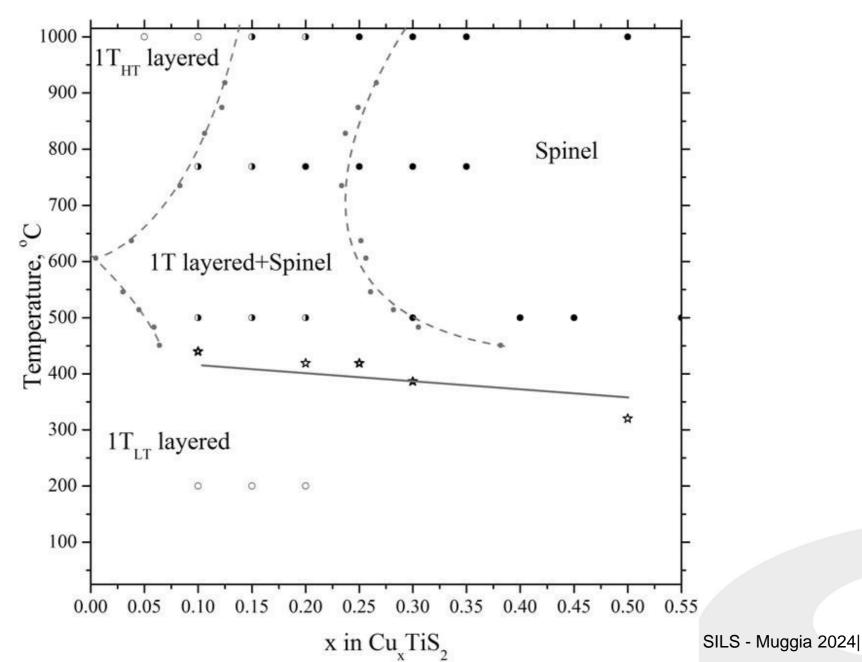








•96

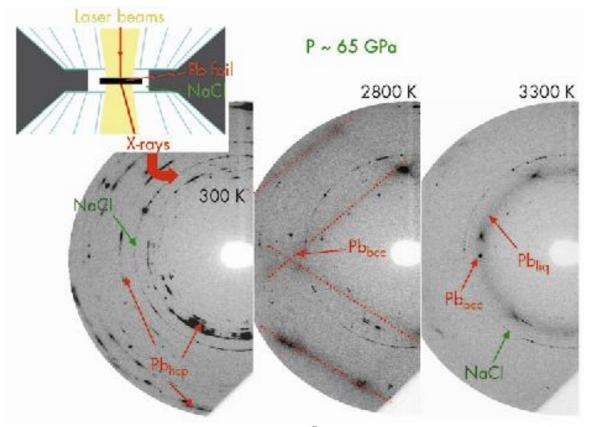




- It has been found that the stability of the layered phase is determined by the distribution of copper atoms between the octahedral and tetrahedral crystallographic sites.
- The occupation of octahedral sites dominates at low temperatures.
- Upon heating, tetrahedral site occupation is limited and the layered phase becomes unstable and transforms to the spinel.
- Further heating allows the distribution of copper between octahedral and tetrahedral sites; the layered phase becomes stable again.



## XRPD in non ambient conditions



### Source: www.esrf.eu

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- The stresses in a material are the sum of the contributions from any externally applied load (applied stress) and those arising from the interactions between individual grains or components that are not completely relaxed when no external load is present (residual stresses).
- Stresses lead to deformation, the distances between lattice planes changes in the direction where stress is present.
- Measuring how the peak position (related to the lattice plane distance by braggs law) changes, at different orientations of the sample gives us information on the amount of stress



 Not being aware of residual tensile stresses, that make materials weaker can have disastrous consequences in construction for example:



Residual stress is often a cause of premature failure of critical components, and was one factor in the collapse of the suspension bridge at Silver Bridge in West Virginia in December 1967. The eyebar links were castings which showed high levels of residual stress, which in one eyebar, encouraged crack growth. When the crack reached a critical size, it grew catastrophically, and from that moment, the whole structure started to fail in a chain reaction. Because the structure failed in less than a minute, 46 drivers and passengers in cars on the bridge at the time were killed.

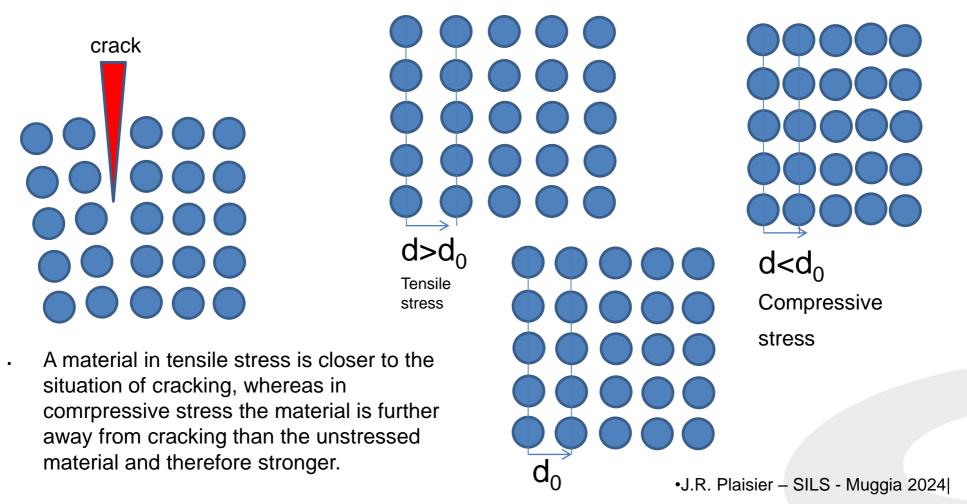


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# Diffraction for stress analysis

•101

On the other hand residual stresses may be induced in materials on purpose. Compressive residual stress maybe induced in order to strengthen it and increase its fatigue life

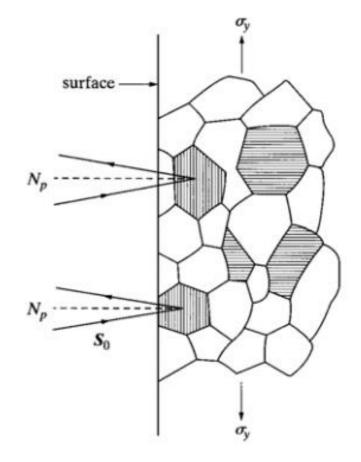




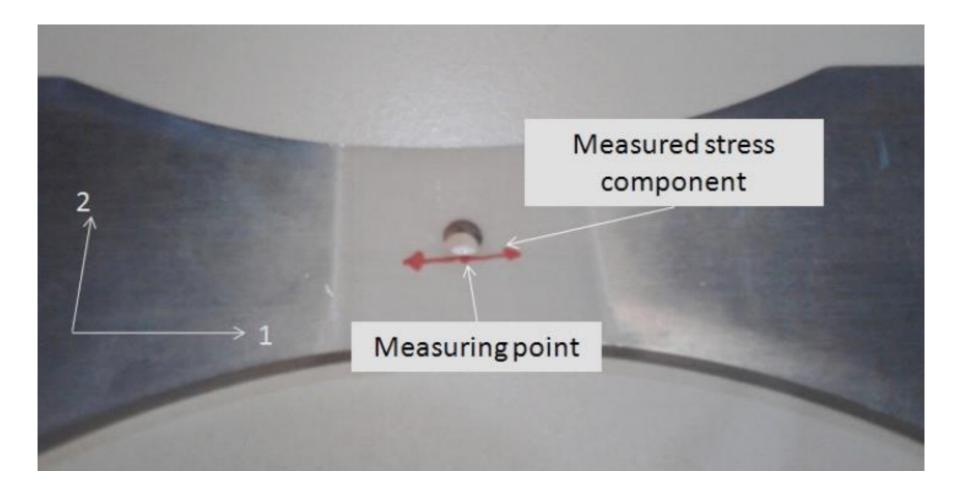
- . It is strain that is actually measured:  $\Delta d/d_0$
- Residual strain changes interplanar spacings, which shifts the positions of diffraction peaks.
- Strain is resolved differently in different physical directions in the sample.
- Engineering materials are polycrystalline, so some grains are always oriented to diffract enabling stress tensors to be determined.



When the d-spacing of a reflection is measured, only grains with the planes oriented in a given direction contribute to diffraction. If we change the orientation of the specimen and remeasure the dspacing we are looking at a different population of grains and we get a different d-spacing due to different stress levels

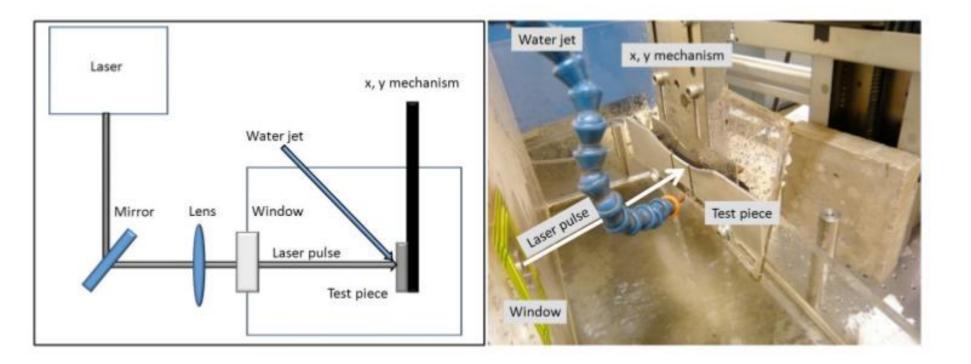




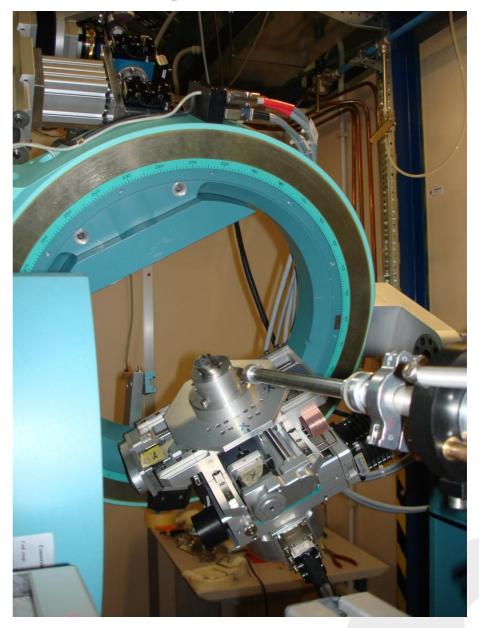


Alloys of aluminium used in the airplane industry were measured to see the effectiveness of laser peening around a hole.



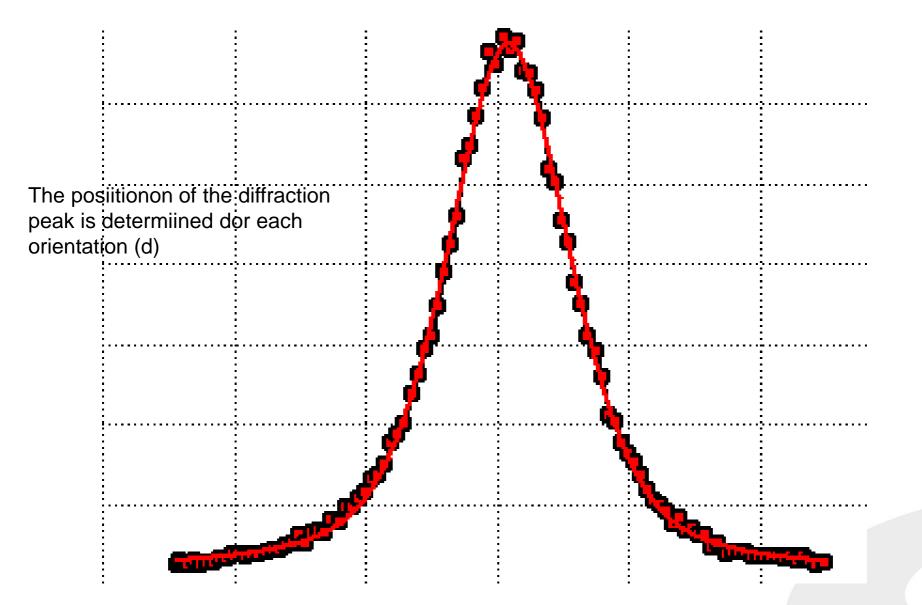




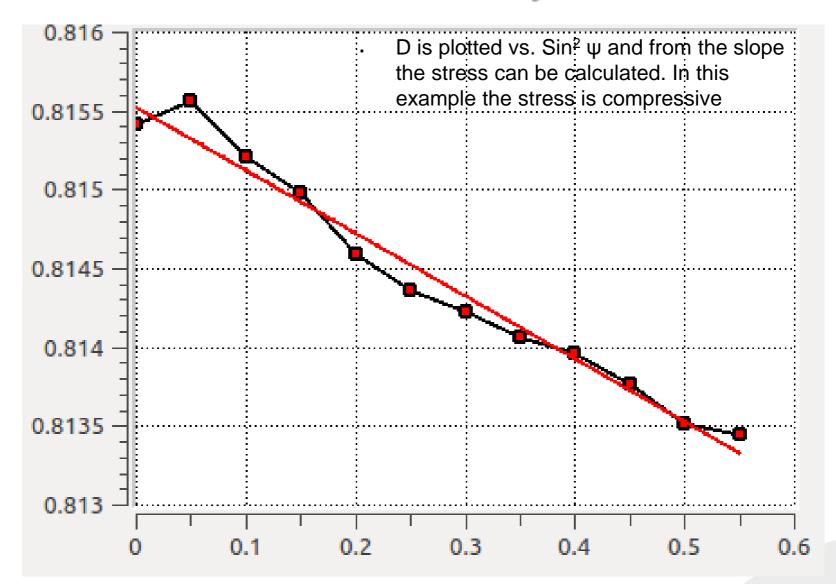


The same diffraction peak is measured for different orientatons of the sample











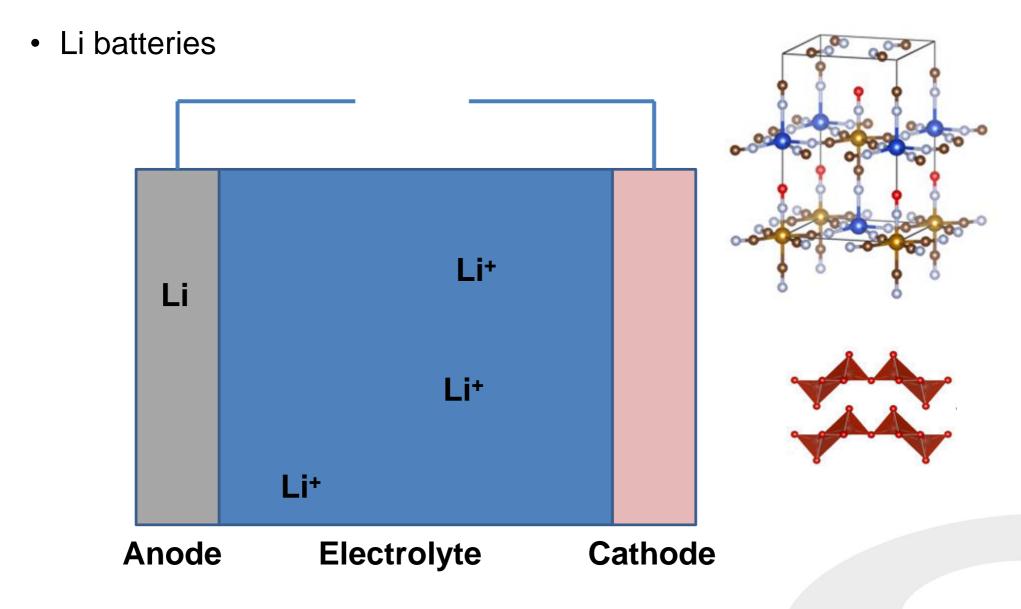
# Diffraction for stress analysis

			Datafiles	
	Name	sin2(psi)	chi	phi
	B3_10_keV	0.20	26.57	0.00
	 33_10_keV	0.25	30.00	0.00
	B3_10_keV	0.30	33.21	0.00
3	B3_10_keV	0.35	36.27	0.00
		Pe	ak positions	
	sin2(psi)	d	2-theta	chisq
5	0.20	0.8146	60.9745	-
6	0.25	0.8144	60.9933	-
7	0.30	0.8142	61.0047	-
8	0.35	0.8141	61.0183	-
			ergy 15.00 ke	
		Wavelen		ngstrom
		Mate	erial <b>6056-T4</b>	ł.
		Miller ind	ices <b>311</b>	
		Elastic Const	ant 72.0 GP	a
		Calculated st	rain <b>-0.0048</b> 9	90
	Calcula	ted residual str	-352 09	9606

 The result showed that laser peening after drilling the hole acutually weakens tha material, whereas first applying laser peening ad subsequently drilling th hole results in a stringer material

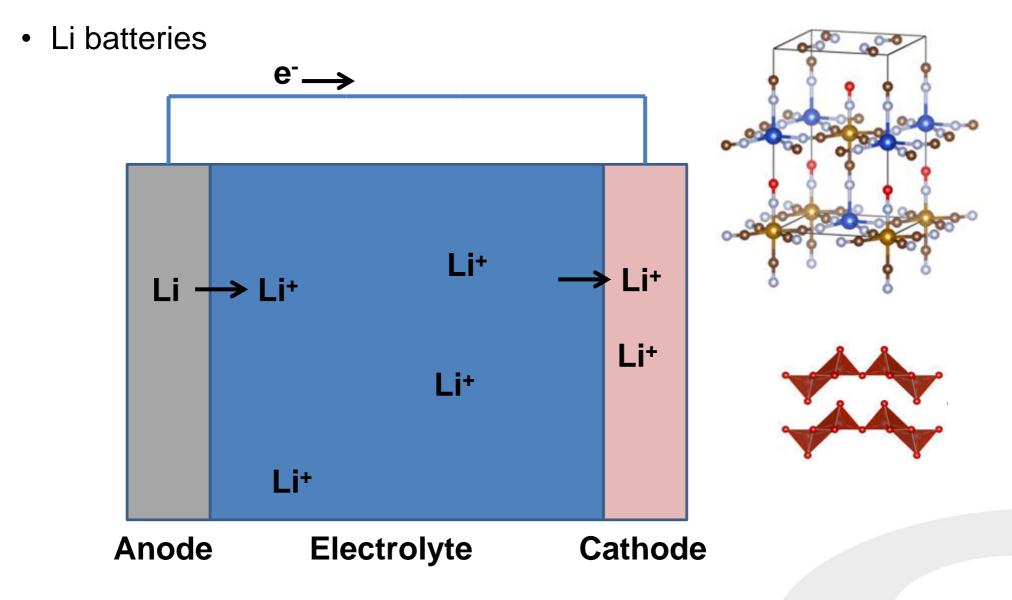


## Operando battery studies





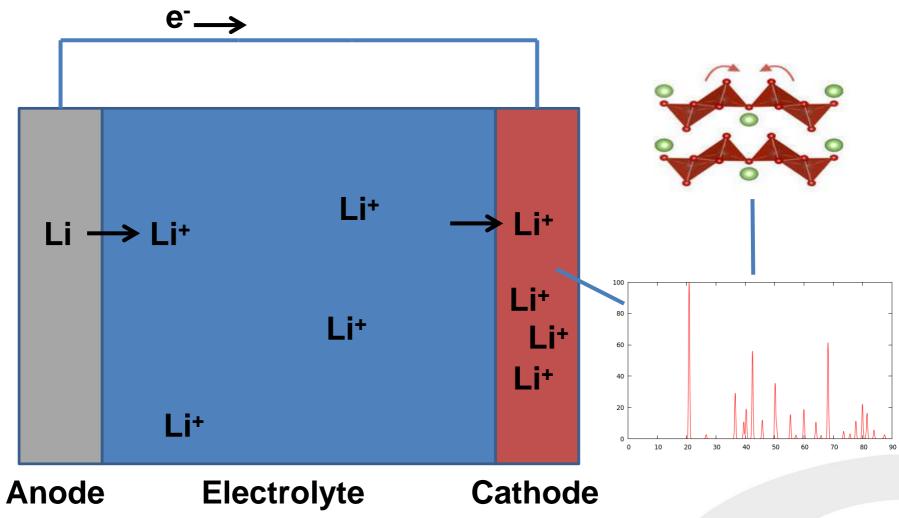
## **Operando** battery studies



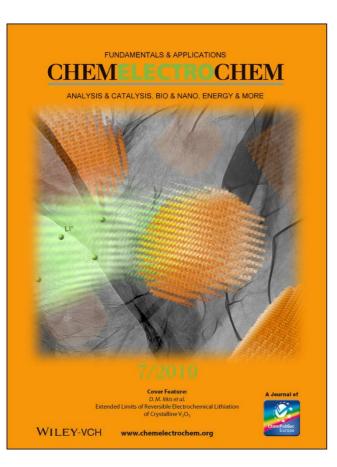


## **Operando** battery studies

• Li batteries



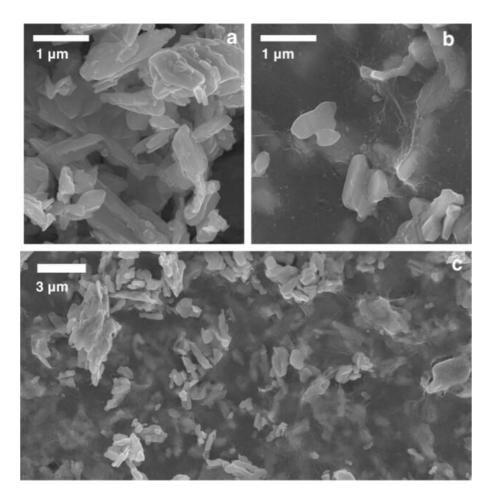




#### Extended Limits of Reversible Electrochemical Lithiation of Crystalline V2O5

Daniil M. Itkis, Victor A. Krivchenko, Anna Ya. Kozmenkova, Margarita S. Pakhotina, Filipp S. Napolskiy, Lara Gigli, Jasper Plaisier, Nellie R. Khasanova and Evgeny V. Antipov



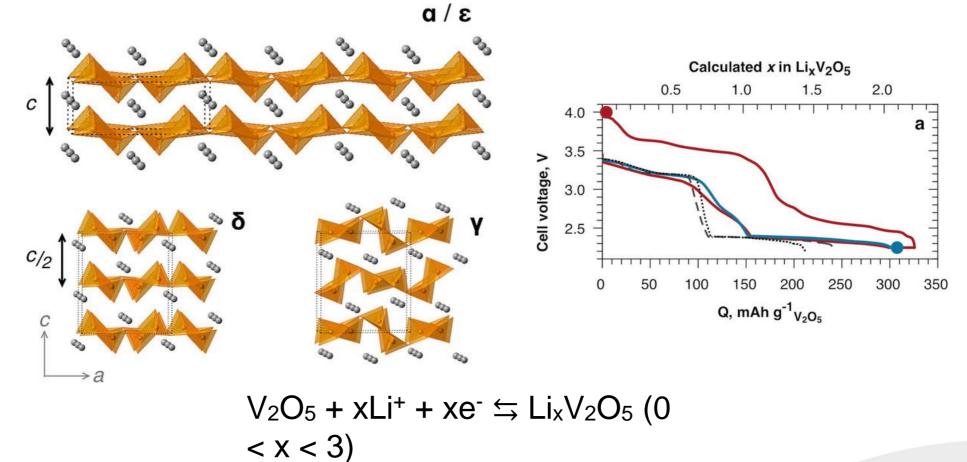


#### Lithiation of Crystalline V<sub>2</sub>O<sub>5</sub>/RGO

- Vanadium (V) oxide was suggested as an attractive host for electrochemical lithium yet in 1970s due to ability of multielectron redox in layered V<sub>2</sub>O<sub>5</sub>
- Insertion of extremely high amounts of lithium (up to 3 moles per mole of oxide) is possible, however, it is believed that insertion/extraction of about 1.8 moles of Li<sup>+</sup> can enable sustainable cycling.



### Lithiation of Crystalline V<sub>2</sub>O<sub>5</sub>/RGO



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#### Calculated x in LixV2O5 α/ε 0.5 1.0 1.5 2.0 4.0 a 3.5 Cell voltage, V 3.0 3 3 3 000 000 С 2.5 150 200 250 300 350 0 50 100 3 2 Q, mAh $g^{-1}V_{2}O_{5}$ 2 033 es. b (002) a (001) γ' (102) (200) a (200) a (101) δ 20 Normalized intensity recharged γ (002) δ (002) γ (200) γ (102) δ (102) ð (200) C/2 discharged a (001) a (200) a (101) C ∧ pristine 10 13 11 12 14 15 20, ° →a $V_2O_5 + xLi^+ + xe^- \leftrightarrows Li_xV_2O_5$ (0) < x < 3)

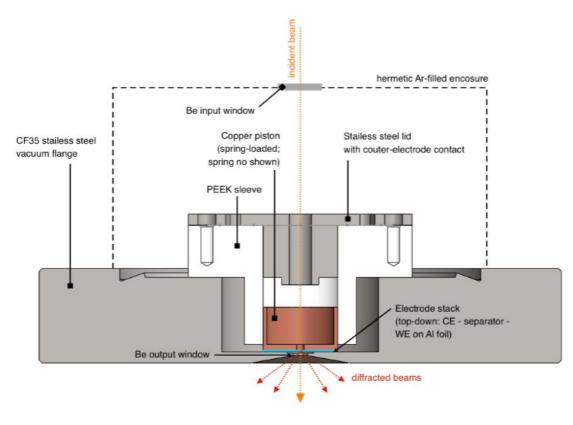
#### Lithiation of Crystalline V<sub>2</sub>O<sub>5</sub>/RGO

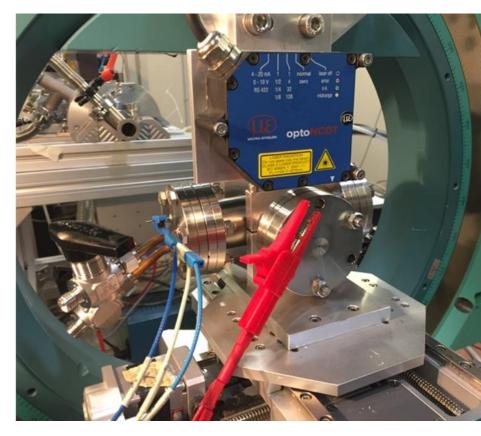
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## Operando battery studies on $V_2O_5/RGO$





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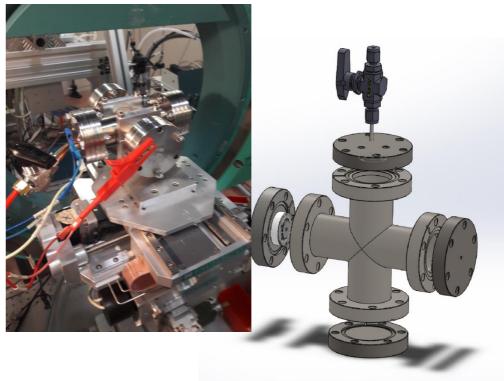
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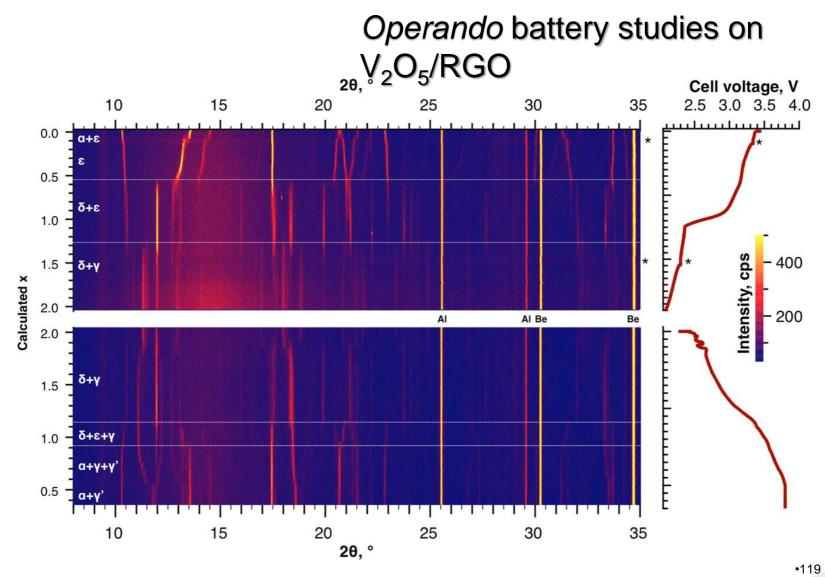
## Operando battery studies on $V_2O_5/RGO$

#### The experiment:

- Cathode: Airbrushed slurry of V<sub>2</sub>O<sub>5</sub> (85%), RGO (10%) and PVDF (5%) on Al
- . Anode: Lithium
- Electrolyte: 1 M LiClO<sub>4</sub> in PC/DME
- · Wavelength 1.033 Angstrom
- . 20 range 8° to 35° with a 0.01° step
- · 0.5 s/point acquisition

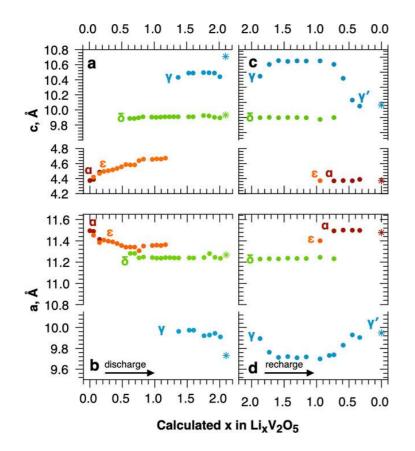


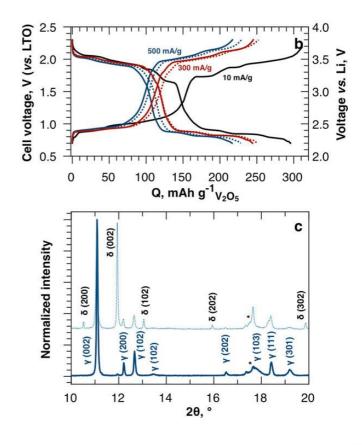




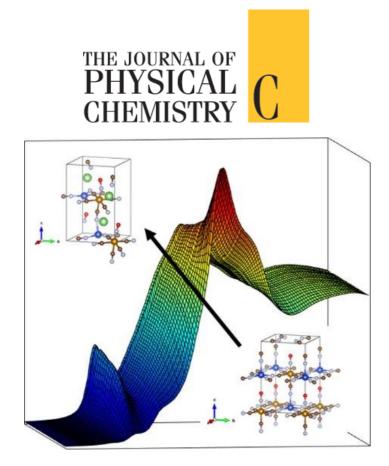


## Operando battery studies on $V_2O_5/RGO$









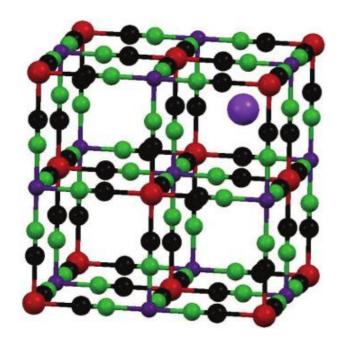
Beyond the Oxygen Redox Strategy in Designing Cathode Material for Batteries: Dynamics of a Prussian Blue-like Cathode Revealed by Operando X-ray Diffraction and Xray Absorption Fine Structure and by a Theoretical Approach

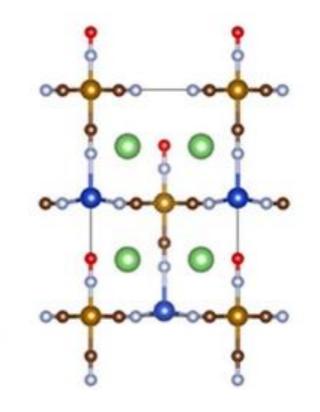
Angelo Mullaliu, Giuliana Aquilanti, Lorenzo Stievano, Paolo Conti, Jasper Plaisier, Sylvain Cristol, Marco Giorgetti





#### Prussian Blue Analogues: CuNP

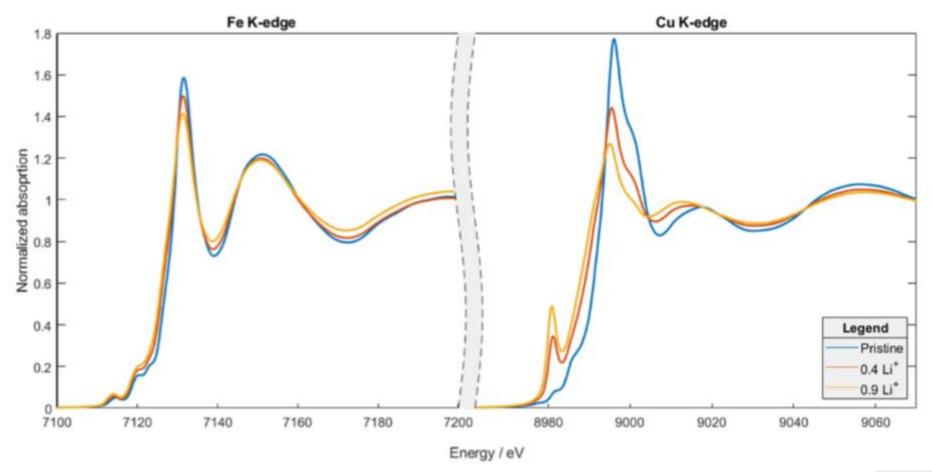




Copper nitroprusside (CuNP), Cu[Fe(CN) $_{5}$ (NO)]



#### **Prussian Blue Analogues: XAS**



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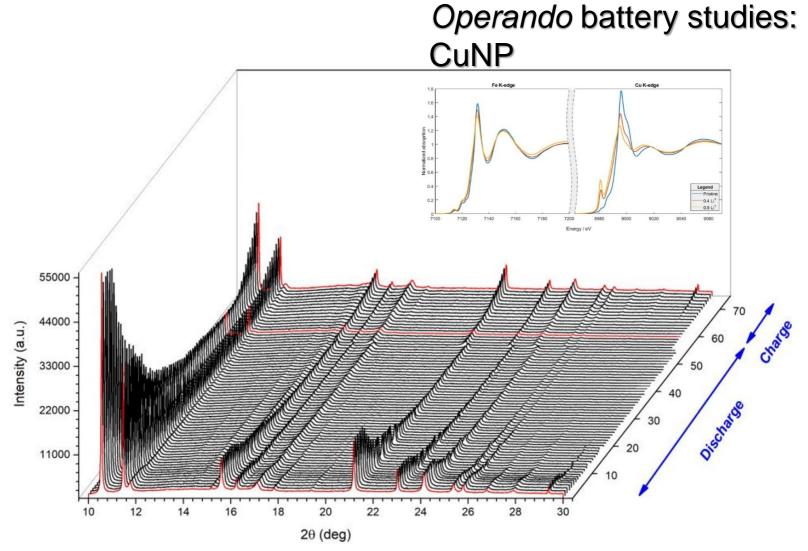
#### *Operando* battery studies: CuNP

The experiment:

- Cathode: CuNP (70%), carbon black (10%), vapor-grown carbon fibers-high density (10%) and PTFE (10%)
   Anodo: Lithium
- Anode: Lithium
- Electrolyte: 1 M LiPF<sub>6</sub> in EC/DC
- · Wavelength 1 Angstrom
- . 20 range 10° to 30° with a 0.01° step
- 0.5 s/point acquisition
- Discharge to 1.8 V versus Li<sup>+</sup>/Li and subsequent charge to 3.5 V versus Li<sup>+</sup>/Li at C/22 current rate

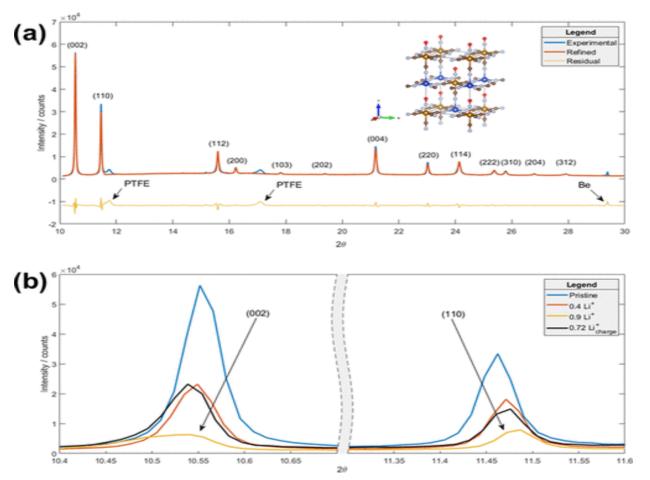








#### *Operando* battery studies: CuNP

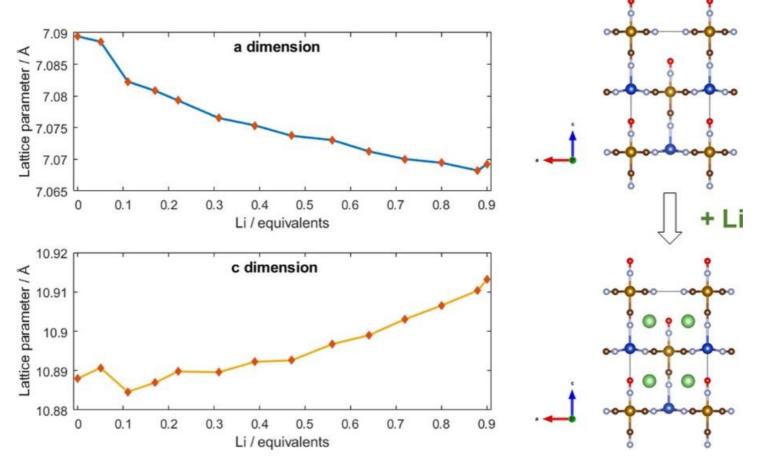




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*Operando* battery studies: CuNP





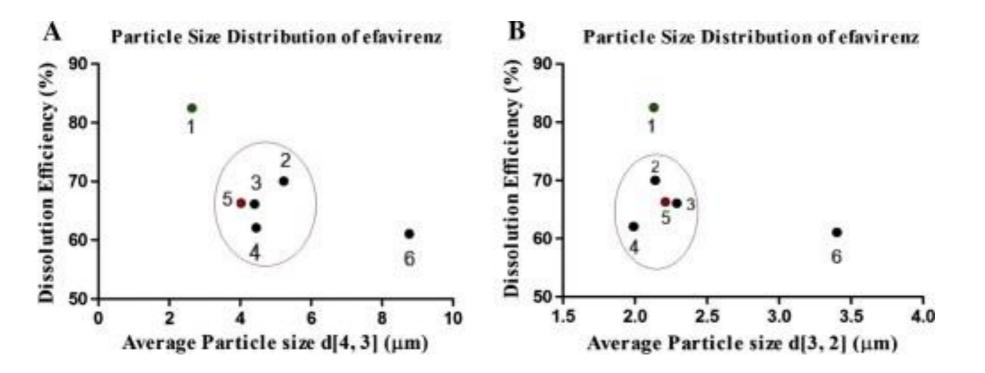
 Correlation between microstructure and bioequivalence in Anti-HIV Drug Efavirenz, C. Fandaruff *et al.*, European Journal of Pharmaceutics and Biopharmaceutics 91, 52-58 (2015)



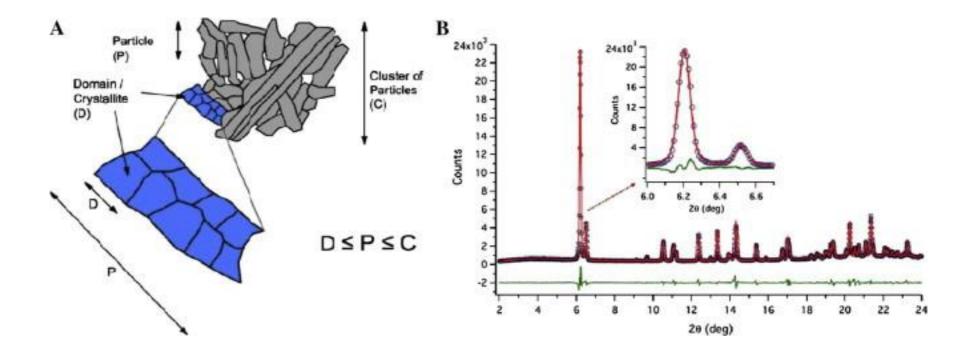


- Polymorphism and particle size distribution can impact the dissolution behaviour and, as a consequence, bioavailability and bioequivalence of poorly soluble drugs, such as Efavirenz (EFV).
- The aim of this work was to study microstructure, a solid-state property of current interest in the pharmaceutical area, in order to find an explanation for the dissolution and bioequivalence behaviour.
- The microstructure of EFV raw materials was studied by Whole Powder Pattern Modelling (WPPM) of X-ray powder diffraction data.

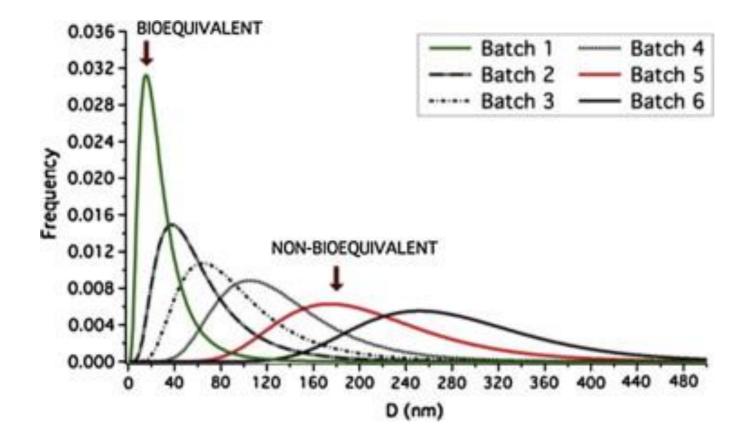






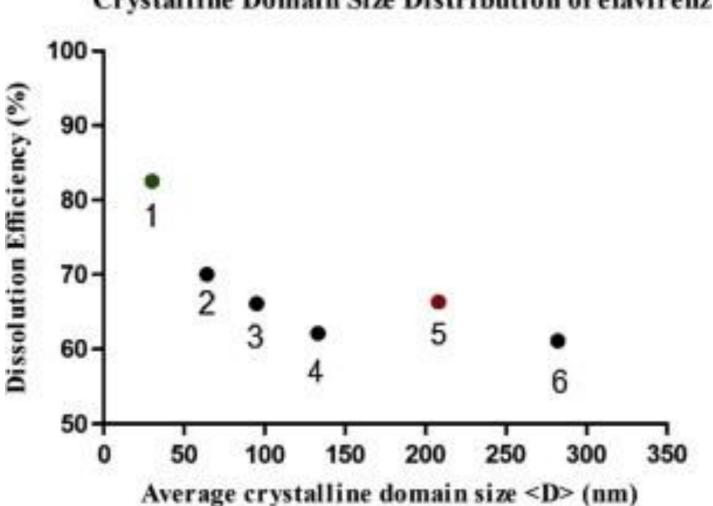






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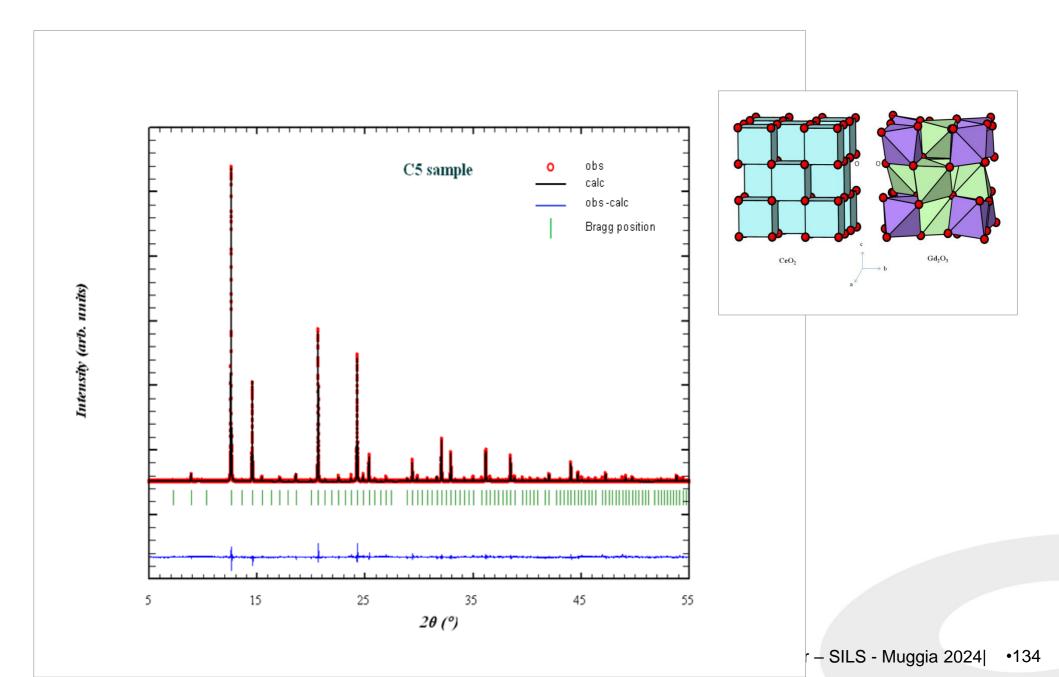


**Crystalline Domain Size Distribution of efavirenz** 

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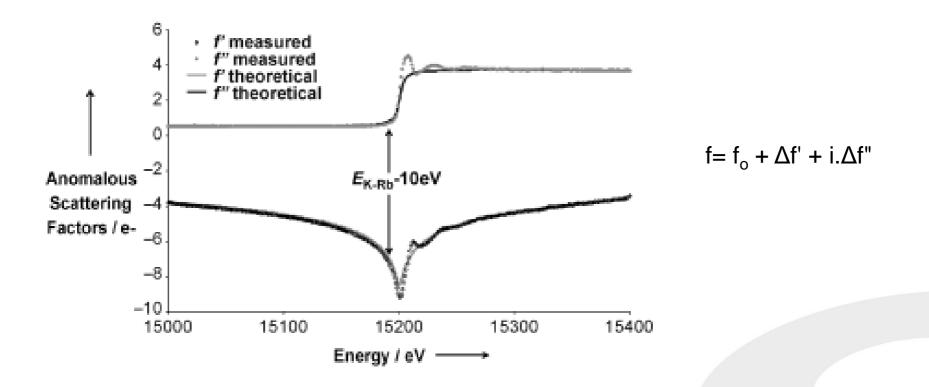


### Structure determination





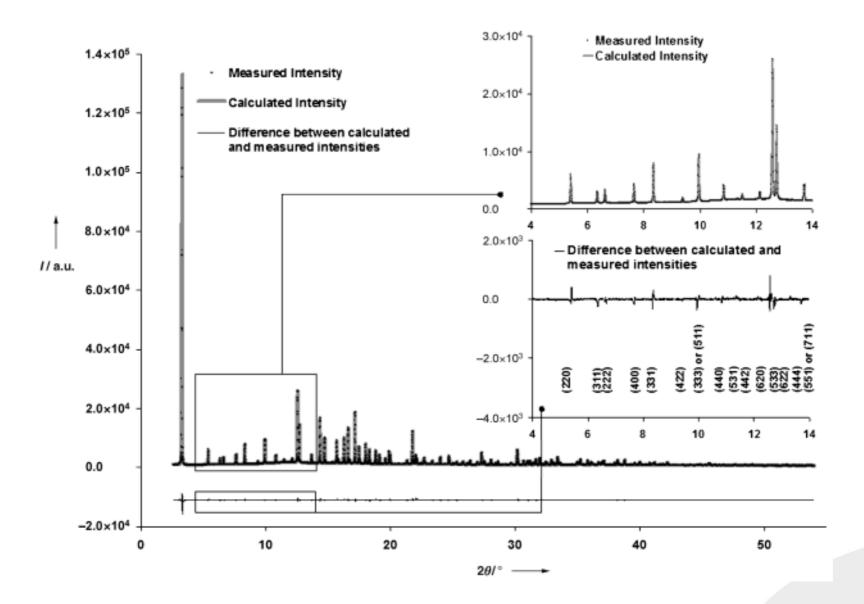
 Direct localzation of atoms in mixed-occupancy powders by resonant contrast diffraction, M.K. Panda *et al.*, H. Palancher *et al.*, Angew. Chem. Int. Ed., 44, 1725-1729 (2005)



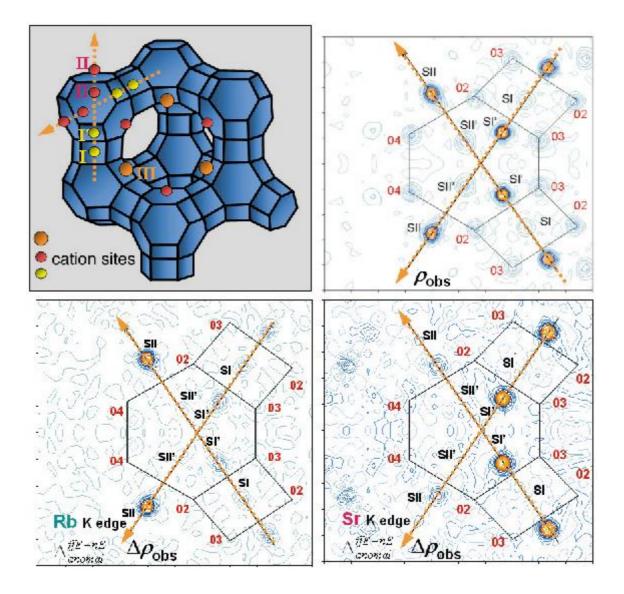


- Resonant scattering variations near an absorption edge provide chemical sensitivity and are used to extract the contribution of a single element to each crystallographic site.
- The method was demonstrated for highly-crystalline solids of industrial interest: bicationic X zeolites to determine Sr<sup>2+</sup> and Rb<sup>+</sup> cation distributions in SrRbX
- Since Sr<sup>2+</sup> and Rb<sup>+</sup> have the same number of electrons and similar neutron scattering lengths ( $b_{Sr} = 0.702 \times 10^{-12} \text{ cm}$ ;  $b_{Rb} = 0.709 \times 10^{-12} \text{ cm}$ ) this is a particularly difficult case for conventional X-ray or neutron diffraction

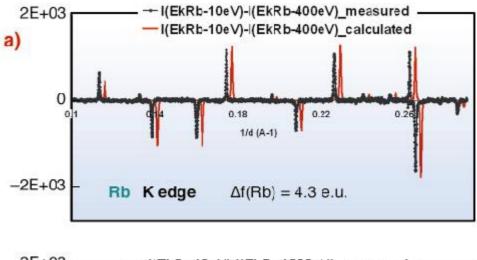


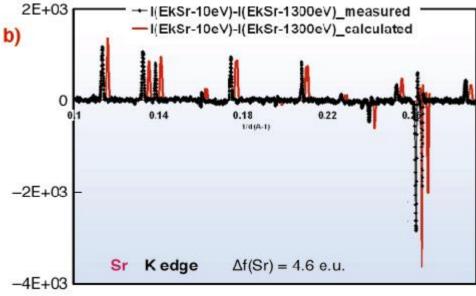














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